

北京计算科学研究中心

11/12/2020

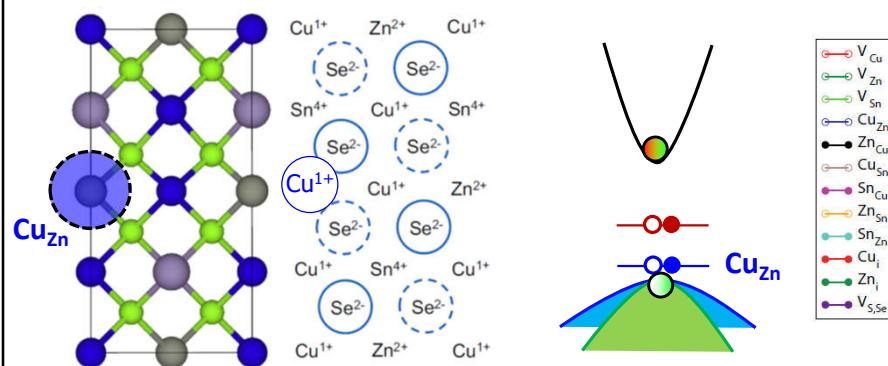
非平衡态下缺陷性质的第一性原理计算

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半导体晶格中的点缺陷

 $\text{Cu}_2\text{ZnSnSe}_4$ 

平衡态下缺陷浓度

CHAPTER 20: POINT DEFECTS

EIGHTH EDITION
Introduction to
Solid State Physics
CHARLES KITTEL

The probability that a given site is vacant is proportional to the Boltzmann factor for thermal equilibrium: $P = \exp(-E_v/k_B T)$, where E_v is the energy required to take an atom from a lattice site inside the crystal to a lattice site on the surface. If there are N atoms, the equilibrium number n of vacancies is given by the Boltzmann factor

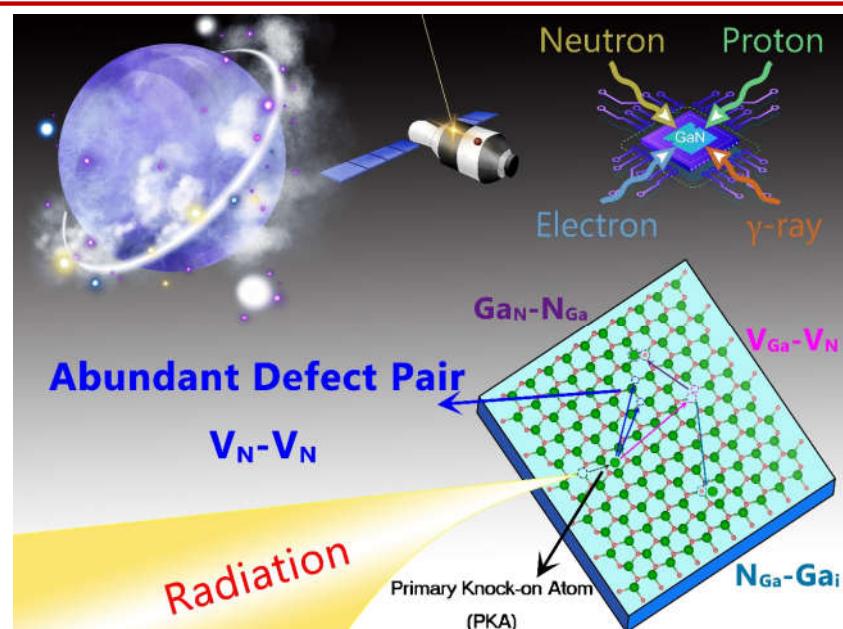
$$\frac{n}{N-n} = \exp(-E_v/k_B T) . \quad (1)$$

If $n \ll N$, then

$$n/N \approx \exp(-E_v/k_B T) . \quad (2)$$

If $E_v \approx 1 \text{ eV}$ and $T \approx 1000 \text{ K}$, then $n/N \approx e^{-12} \approx 10^{-5}$.

辐照下的缺陷

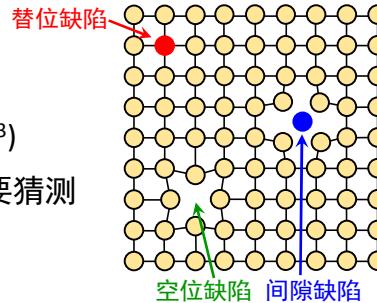


科学问题：缺陷的研究和调控在方法上仍有困难

◆ 实验挑战：难以直接观测

浓度低： 10^{-7} - 10^{-4} (10^{15} - 10^{18} cm $^{-3}$)

多种缺陷共存，难以区分，需要猜测



◆ 理论挑战：难以精确计算模拟，计算误差大，过程复杂

有限超原胞导致的误差（精确计算需考虑百万-千万原子）

缺陷种类和构型繁多，交换关联势近似，都导致误差

Zhang *et al.*, Phys. Rev. Lett. 110, 166404 (2013)

Freysoldt *et al.*, Rev. Mod. Phys. 86, 253 (2014)

Grasser *et al.*, Microelectronics Reliability 87, 286 (2018)

提纲

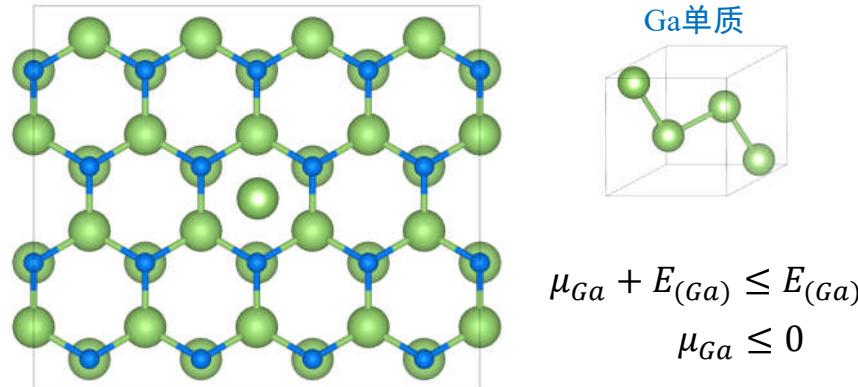
1. 计算辐照下可能产生的各种缺陷的平衡态性质

形成能、能级和载流子俘获截面

2. 模拟辐照下化学键的断裂和缺陷形成过程

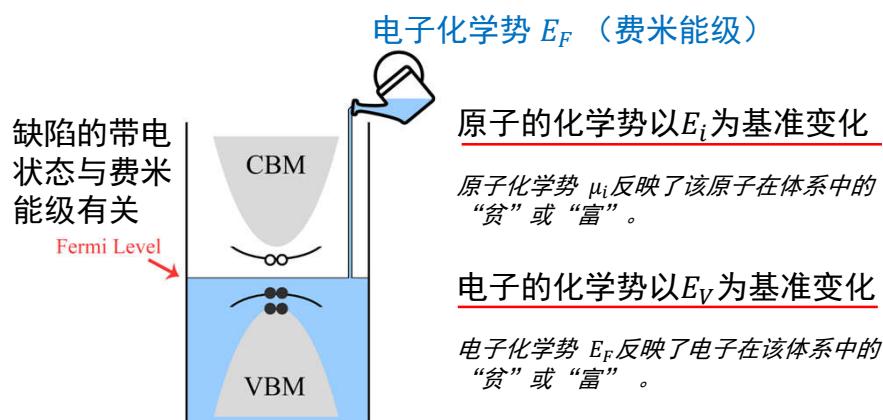
缺陷形成能（电中性）

$$\Delta H_f(\alpha, q = 0) = E(\alpha, q = 0) - E(\text{host}) + \sum n_i(\mu_i + E_i)$$



缺陷形成能（缺陷带电）

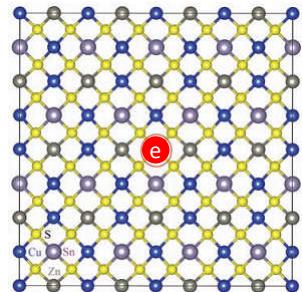
$$\Delta H_f(\alpha, q) = E(\alpha, q) - E(\text{host}) + \sum n_i(\mu_i + E_i) + q(E_F + E_V + \Delta V)$$



缺陷形成能的计算

$$\Delta H_f(\alpha, q) = E(\alpha, q) - E(\text{host}) + \sum n_i(\mu_i + E_i) + q(E_F + E_V + \Delta V)$$

(1) (2) (3) (4) (5) (6) (7) (8)

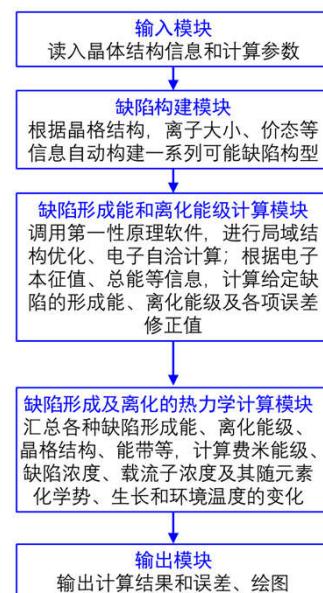


- ① 一含缺陷超胞的总能
- ② 一无缺陷超胞的总能
- ③ 一原子化学势
- ④ 一元素单质相的总能
- ⑤ 一可能的带电状态
- ⑥ 一费米能级
- ⑦ 一价带顶的能量
- ⑧ 一静电势修正项

Semiconductor Defect Ab initio Simulation Code



1. 自动确定组成元素和掺杂元素的热力学化学势范围（基于材料基因数据库）
2. 自动产生本征缺陷、杂质及复合缺陷的构型
3. 自动提交第一性原理计算并处理数据
4. 自动计算缺陷形成能和缺陷能级
5. 自动完成镜像电荷、带隙等修正
6. 自动动态计算载流子浓度与费米能级
7. **自动计算高浓度复合中心缺陷的载流子俘获截面**



SDASC程序的三个模块



$$\Delta H_f(\alpha, q) = E(\alpha, q) - E(host) + \sum_{①②} n_i(\mu_i + E_i) + q(E_F + E_V + \Delta V)$$

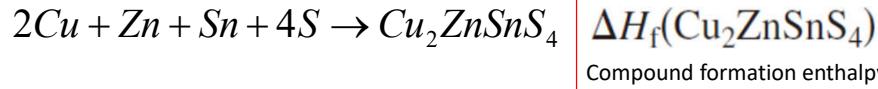
$$③④⑤⑥⑦⑧$$

化学势稳定区域的判断

$$\Delta H_f(\alpha, q) = E(\alpha, q) - E(host) + \sum_{①②} n_i(\mu_i + E_i) + q(E_F + E_V + \Delta V)$$

$$③④⑤⑥⑦⑧$$

Limit to the element chemical potentials



Under equilibrium:

$$2\mu_{Cu} + \mu_{Zn} + \mu_{Sn} + 4\mu_S = \Delta H_f(Cu_2ZnSnS_4)$$

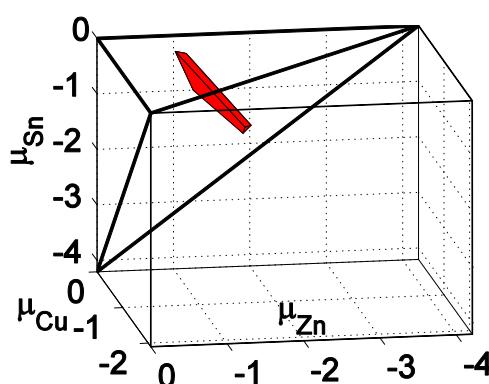
No secondary compounds:

$$\begin{aligned}\mu_{Cu} + \mu_S &< \Delta H_f(CuS) \\ 2\mu_{Cu} + \mu_S &< \Delta H_f(Cu_2S) \\ \mu_{Zn} + \mu_S &< \Delta H_f(ZnS) \\ \mu_{Sn} + \mu_S &< \Delta H_f(SnS) \\ \mu_{Sn} + 2\mu_S &< \Delta H_f(SnS_2) \\ 2\mu_{Cu} + \mu_{Sn} + 3\mu_S &< \Delta H_f(Cu_2SnS_3)\end{aligned}$$

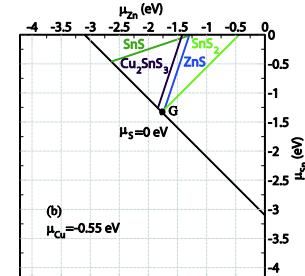
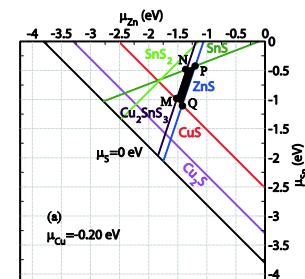
No elemental phase:

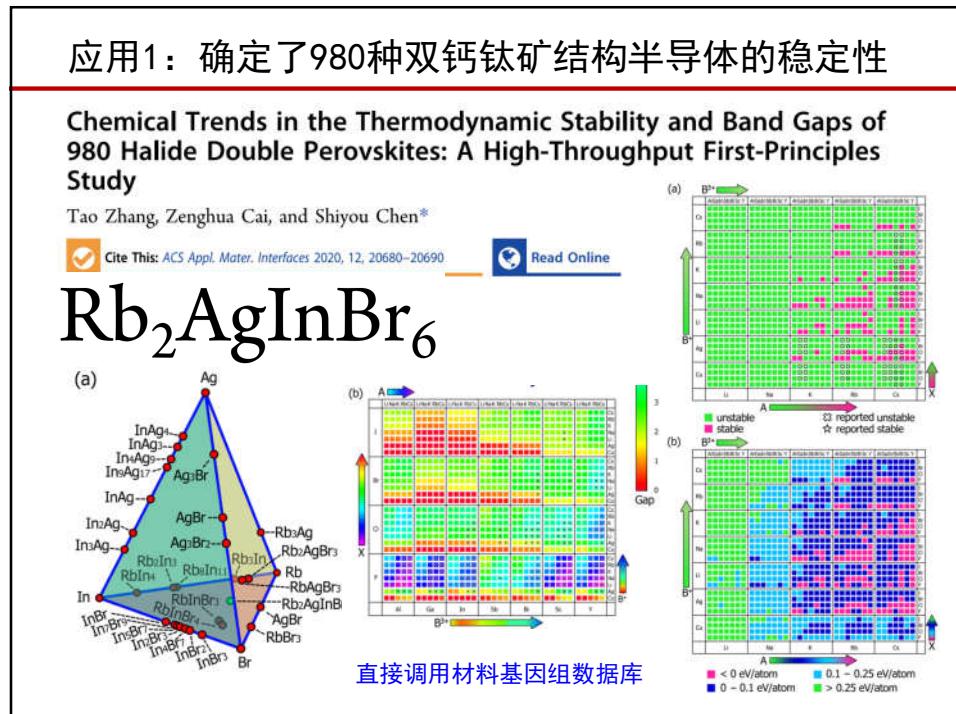
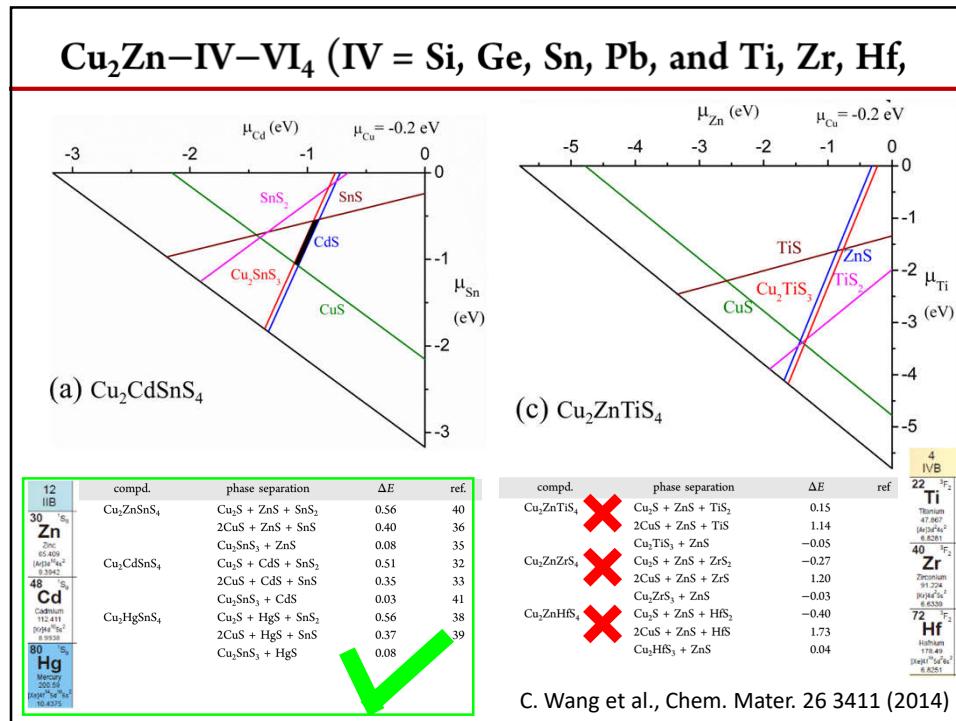
$$\begin{aligned}\mu_{Cu} &< 0 \\ \mu_{Zn} &< 0 \\ \mu_{Sn} &< 0 \\ \mu_S &< 0\end{aligned}$$

Narrow stable region in chemical potential space



- ◆ Narrow stable region.
- ◆ ZnS, CuS, SnS form very easily.
- ◆ Difficult to synthesize stoichiometric Cu_2ZnSnS_4

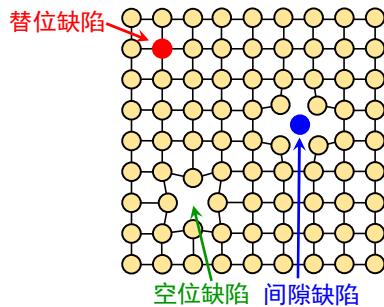




缺陷构型的构建

$$\Delta H_f(\alpha, q) = E(\alpha, q) - E(\text{host}) + \sum n_i (\mu_i + E_i) + q(E_F + E_V + \Delta V)$$

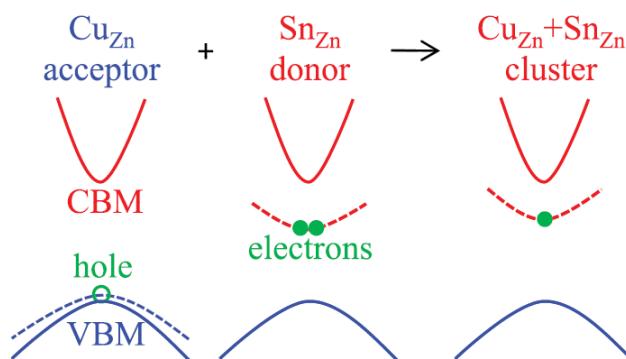
① ② ③ ④ ⑤ ⑥ ⑦ ⑧



- ◆ 空位和替位：
考虑不等价原子位置
- ◆ 间隙：随机大量结构

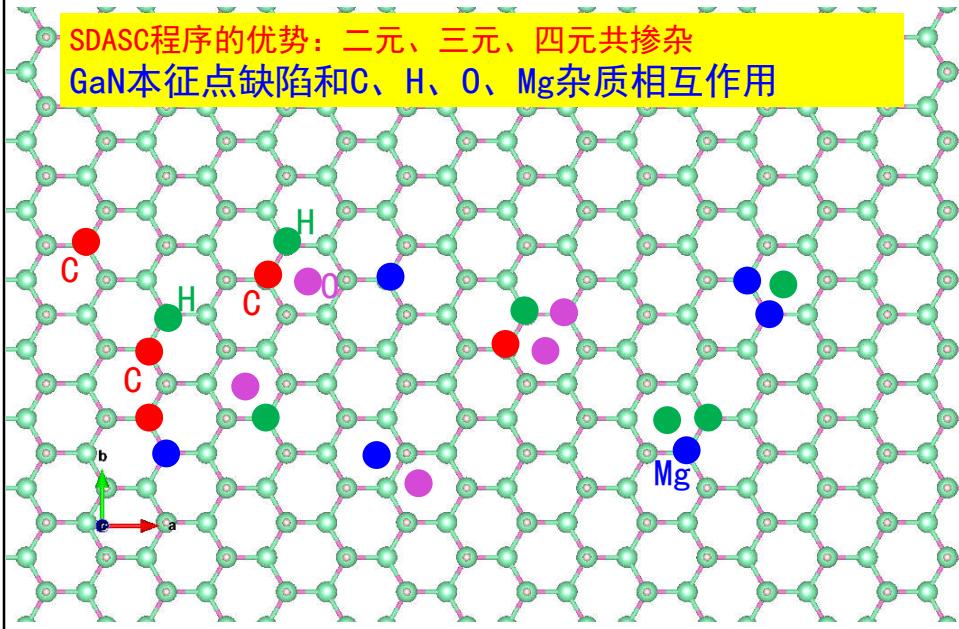
施主-受主相互补偿缺陷簇

1. 计算所有的点缺陷的形成能，区分出施主和受主缺陷
2. 将浓度比较高的施主和受主缺陷组合，形成复合缺陷簇



Chen et al. *Appl. Phys. Lett.* **101**, 223901 (2012)

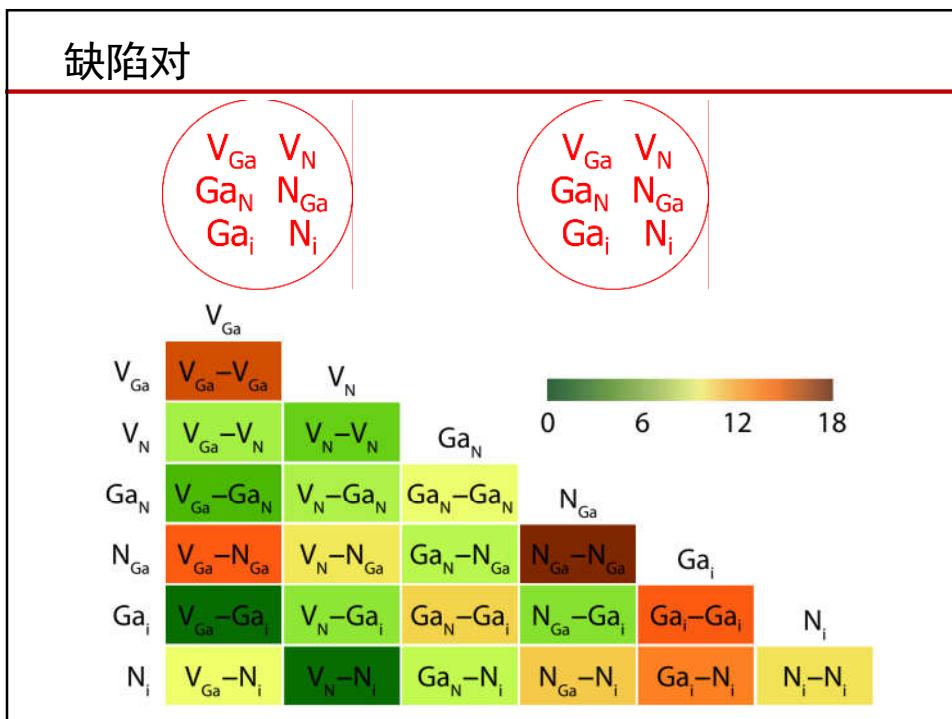
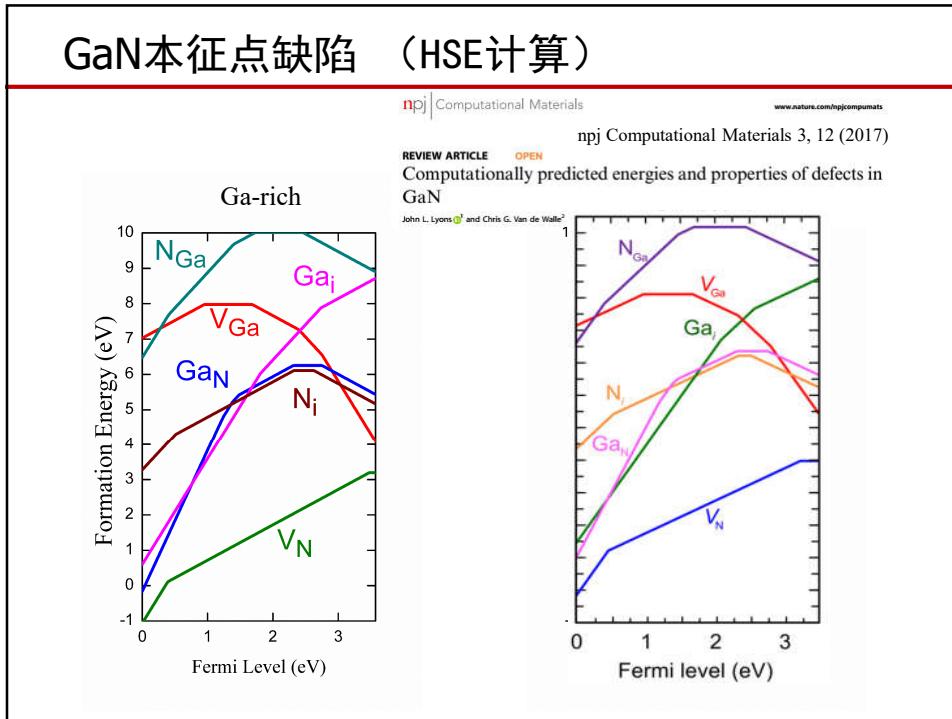
本征缺陷、杂质组成的缺陷-杂质簇



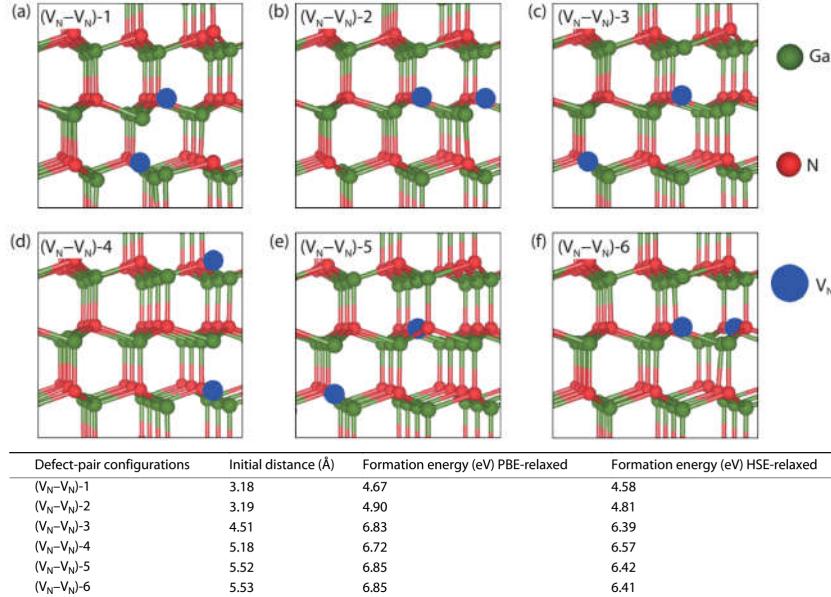
程序应用实例1



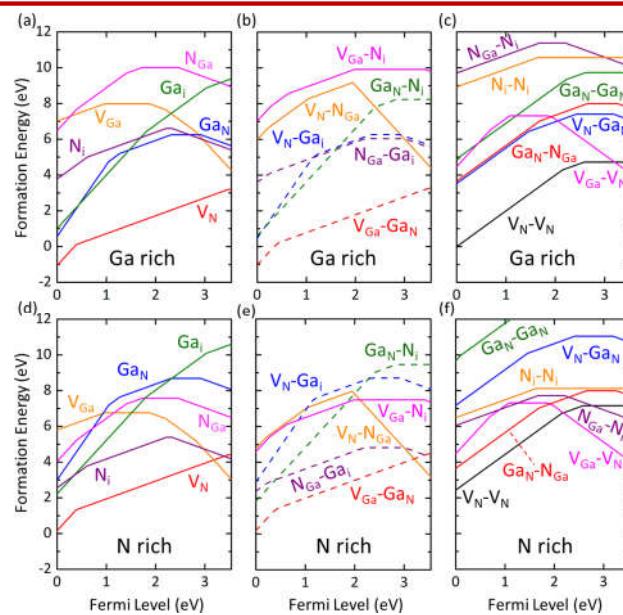
半导体缺陷第一性原理计算程序
(Semiconductor Defect Ab initio Simulation Code)



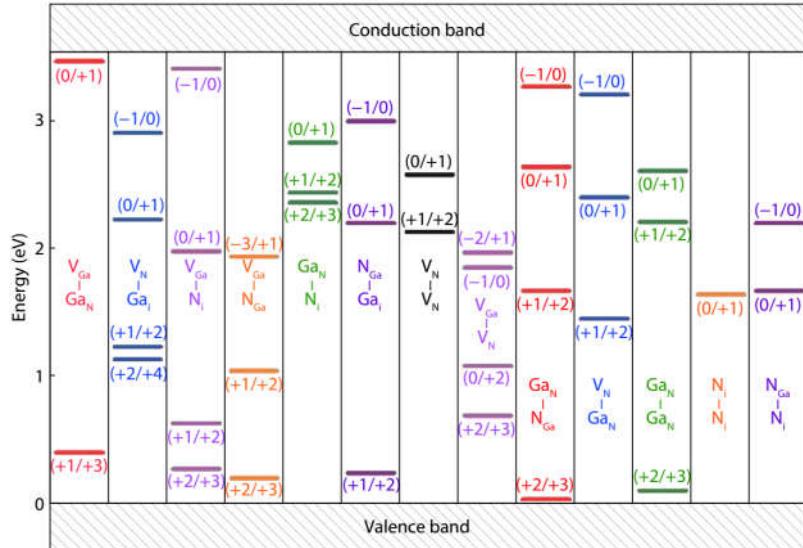
N空位对



GaN本征点缺陷对的形成能

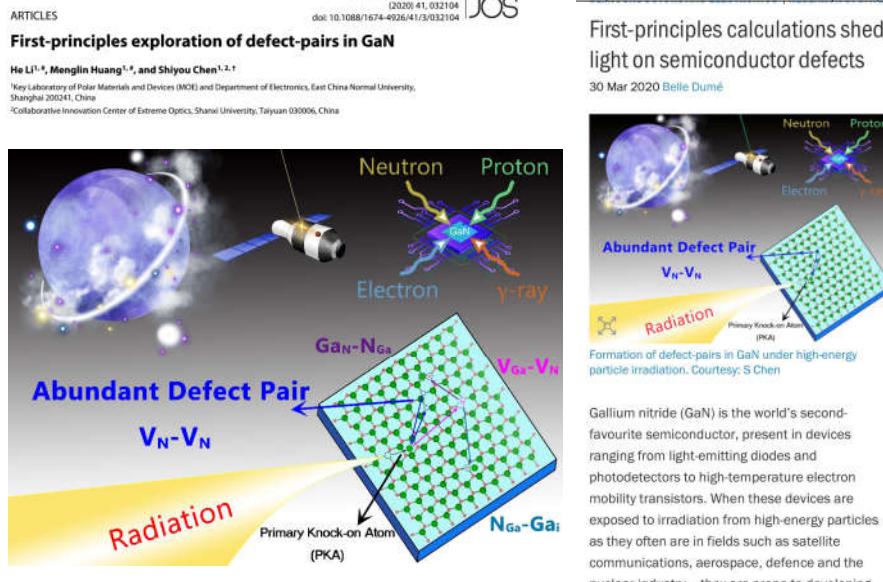


GaN本征点缺陷对的离化能级

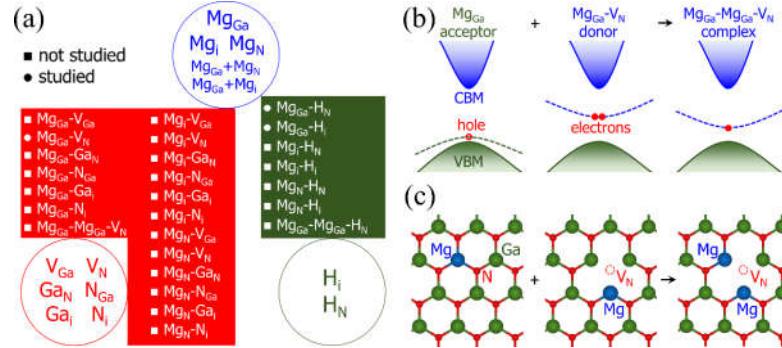


Journal of Semiconductors 41, 032104 (2020)

辐照下GaN中缺陷对

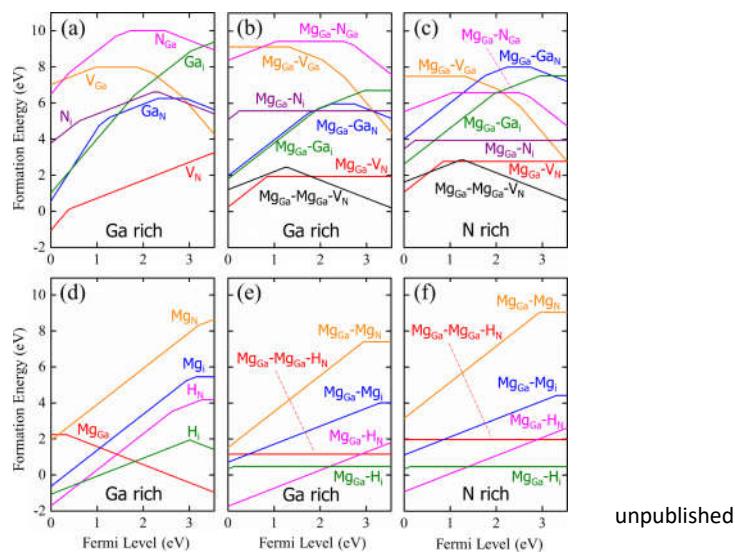


Mg、H杂质与本征缺陷形成的缺陷簇

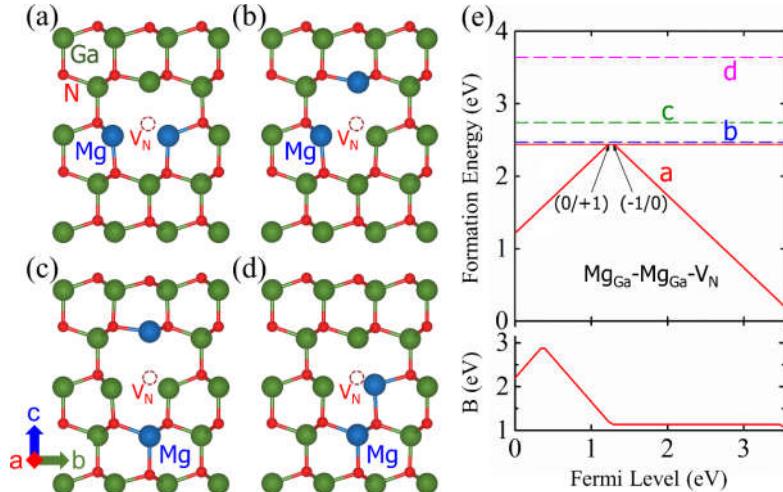


大部分无人算过

$\text{Mg}_{\text{Ga}}\text{-}\text{Mg}_{\text{Ga}}\text{-}\text{V}_\text{N}$ 、 $\text{Mg}_{\text{Ga}}\text{-}\text{Mg}_{\text{Ga}}\text{-}\text{H}_\text{N}$

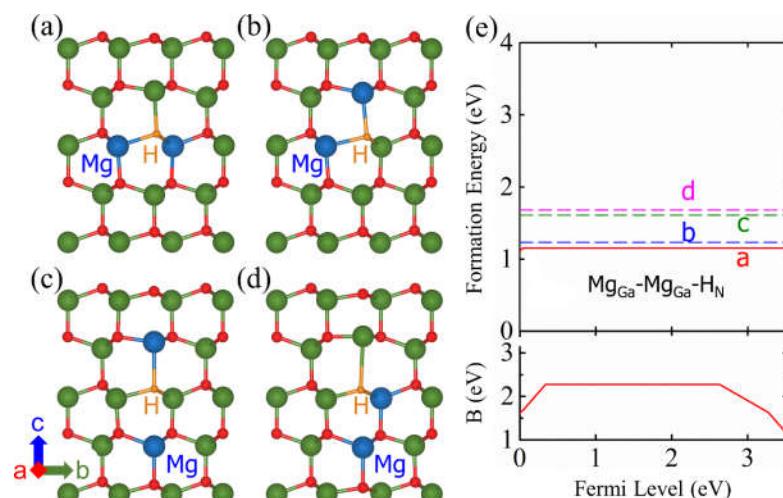


Mg_{Ga}-Mg_{Ga}-V_N

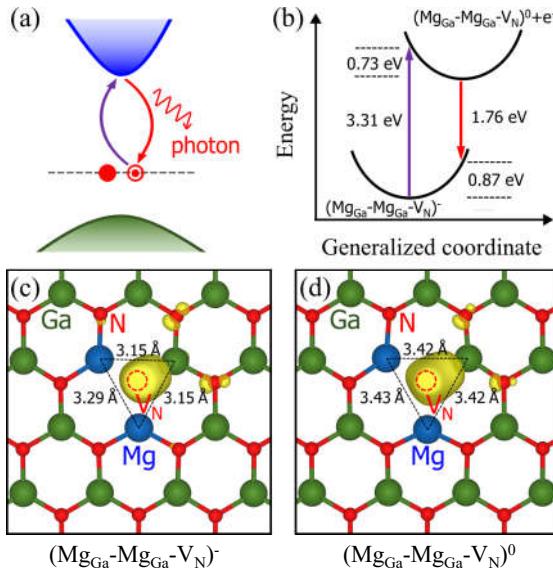


unpublished

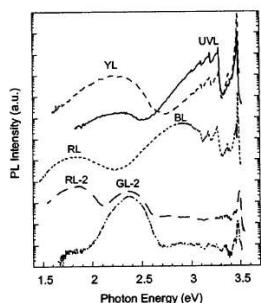
Mg_{Ga}-Mg_{Ga}-H_N



缺陷的光致发光



GaN绿光和红光峰来源缺陷的新解释



Yellow luminescence: 2.2 eV

Ultra-violet luminescence: 3.25 eV

Blue luminescence: 2.7-2.9 eV (low temperature)

Red luminescence: 1.8 eV (extremely Ga-rich)

Green luminescence: 2.5 eV (extremely Ga-rich)

M. A. Reschchikov and H. Morkoç, *J. Appl. Phys.* **97**, 061301 (2005)

FIG. 13. PL spectra from undoped GaN at 15 K. The spectra are plotted in logarithmic scale and displaced vertically for better viewing.

Blue Luminescence:	Mg_{Ga}	2.7-2.9 eV	$\text{C}_N: (0/+)$	$\text{C}_N+\text{H}_i: (0/+)$
Ultraviolet Luminescence:	$\text{Mg}_{\text{Ga}}-\text{H}_i$	3.3 eV		
Green Luminescence:	V_N	2.5 eV	$\text{C}_N\text{H}_N: (+/2+)$	
Red Luminescence:	$\text{Mg}_{\text{Ga}}-\text{V}_N$	1.8 eV	$\text{C}_N\text{V}_N: (0/+)$	$2(\text{Mg}_{\text{Ga}})+\text{V}_N$
Yellow Luminescence:	C_N	2.2-2.3 eV	$\text{C}_N: (-/0)$	

程序应用实例2

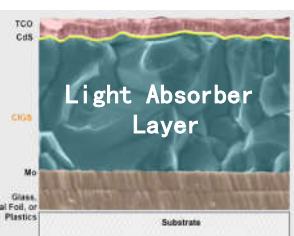
多元、低对称性半导体 光伏材料的点缺陷

光伏半导体的发展趋势

Solar Cell



Device Architecture



Ideal light absorber

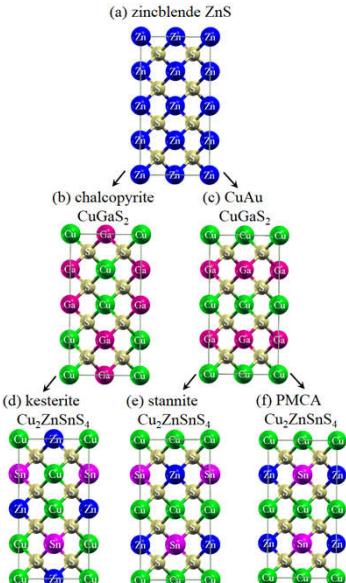
- ① Band gap: direct, 1.1-1.5 eV
- ② Suitable band edge
- ③ High carrier mobility
- ④ Environment friendly
- ⑤ Earth abundant, cheap
- ⑥ ...

More and more elements

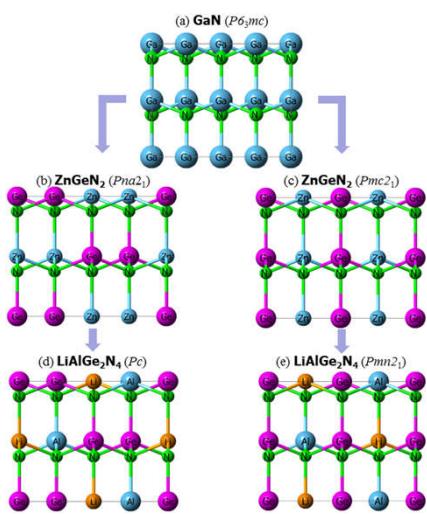
1950	1960	1970	1980	1990	2000
Si	GaAs	CuInSe ₂	GaInP/GaAs/Ge	Cu ₂ ZnSn(S, Se) ₄	CH ₃ NH ₃ PbI ₃
CdTe	CuGaSe ₂				Sb ₂ Se ₃

Crystal Structure Mutation

zincblende-derived



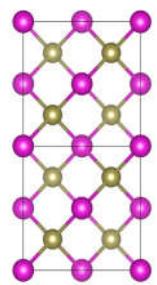
wurtzite-derived



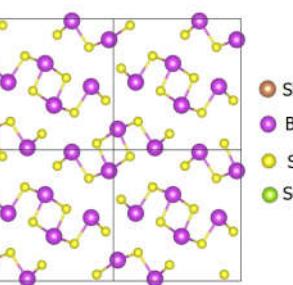
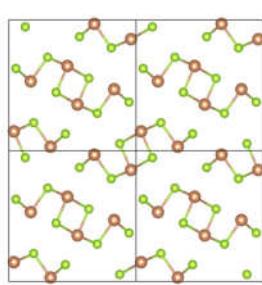
Chen et al, Phys. Rev. B 79, 165211 (2009)
Cai et al, Chem. Mater. 22, 7757 (2015)

Beyond Tetrahedral Coordination

四配位结构
硫族半导体



准一维结构
硫族半导体



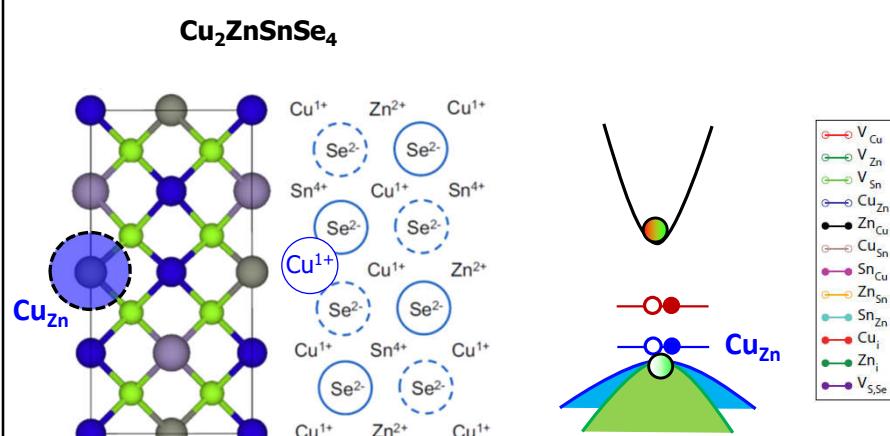
高对称性

低对称性

Outline

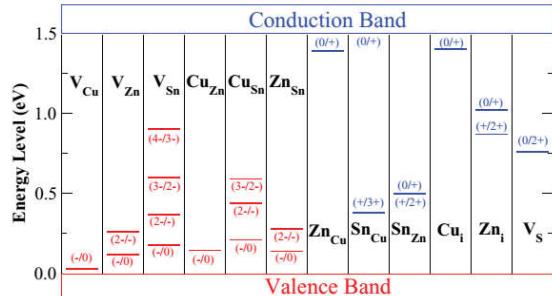
- ◆ $\text{Cu}_2\text{ZnSn}(\text{S},\text{Se})_4$
 - ◆ $\text{Cu}(\text{In},\text{Ga})\text{Se}_2$
 - ◆ $\text{Sb}_2\text{Se}_3, \text{Sb}_2\text{S}_3, \text{Bi}_2\text{S}_3$
- 多元半导体
- 低对称性半导体
结构多元

Easy formation of Intrinsic Defects

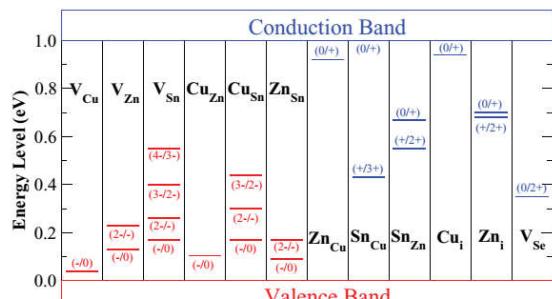


Ionization Levels of Various Defects

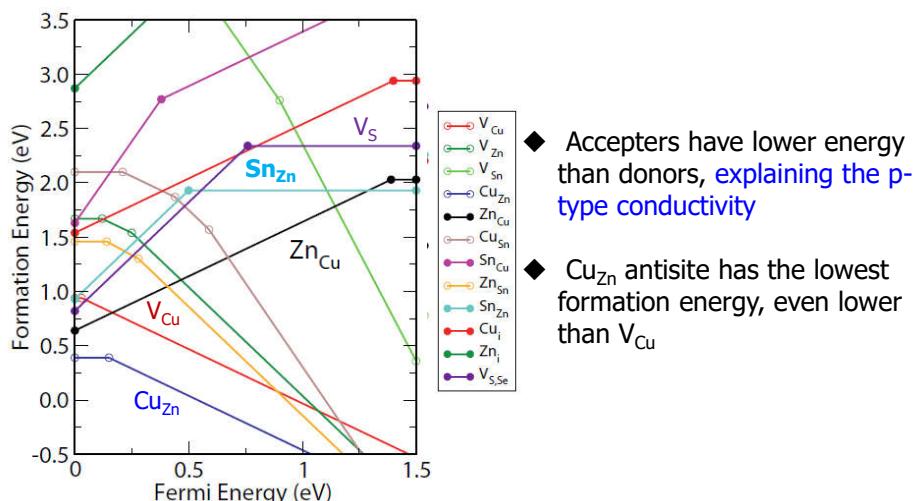
Cu₂ZnSnS₄



Cu₂ZnSnSe₄

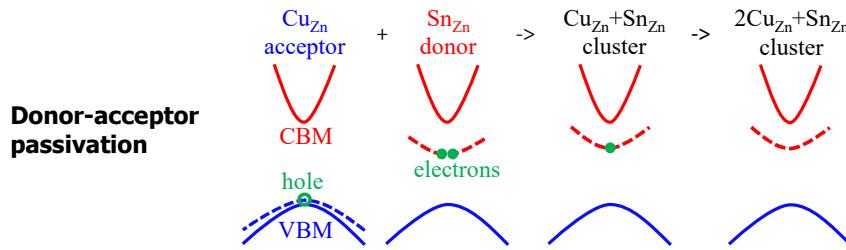


Defect Formation Energies



Chen et al., Adv. Mater. 25, 1522 (2013)
 Phys. Rev. B 81, 245204 (2010)
 Appl. Phys. Lett. 96, 021902 (2010)

Defect clusters $\text{Cu}_{\text{Zn}}+\text{Sn}_{\text{Zn}}$, $2\text{Cu}_{\text{Zn}}+\text{Sn}_{\text{Zn}}$

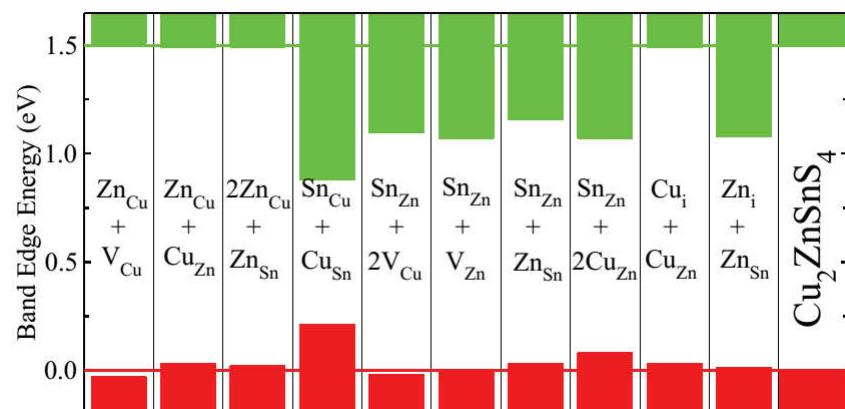


Three factors lower the formation energy:

- ◆ donor-acceptor passivation: donor electron goes to acceptor level
- ◆ Coulomb attraction between charged donor and acceptor
- ◆ strain relief

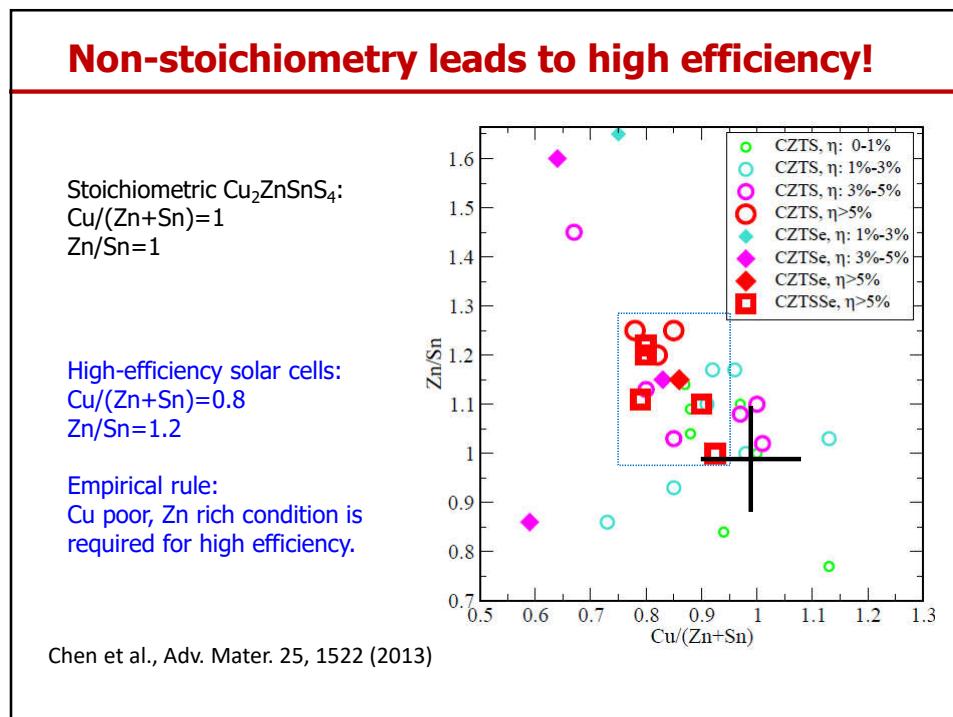
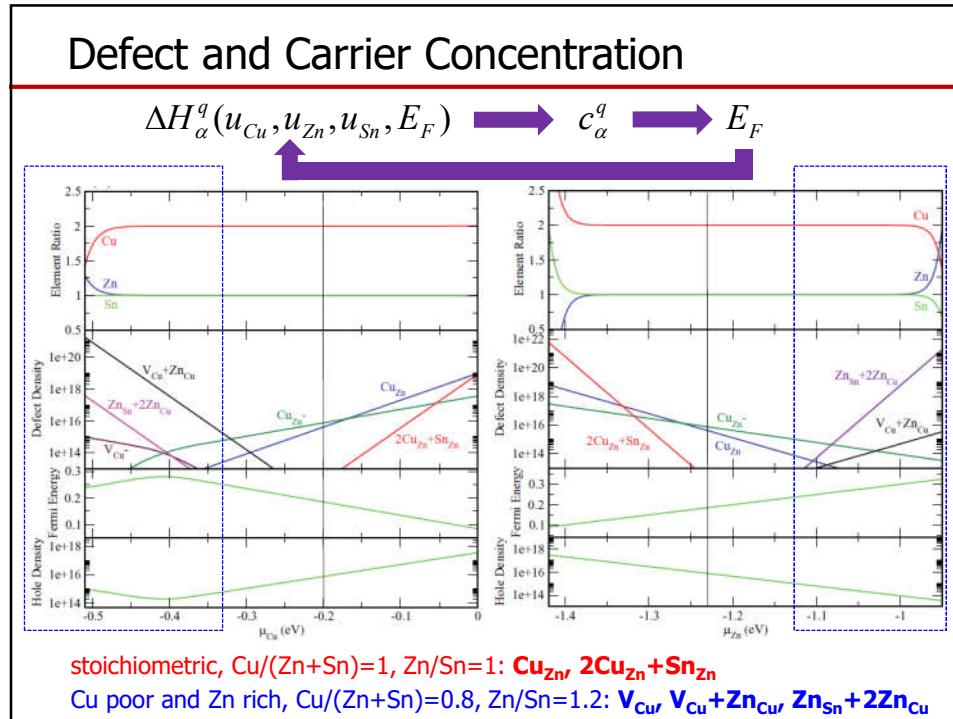
Chen et al., Appl. Phys. Lett. 101, 223901 (2012)

Band edge shift induced by defect complexes

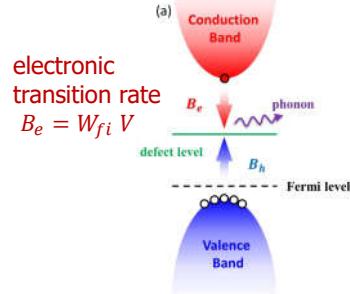
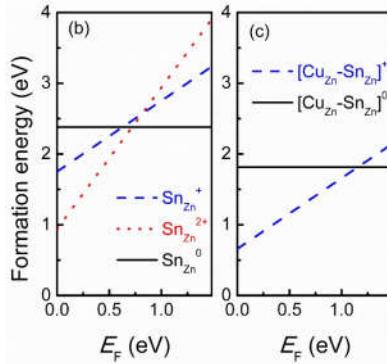


◆ $\text{V}_{\text{Cu}}+\text{Zn}_{\text{Cu}}$, $\text{Zn}_{\text{Sn}}+2\text{Zn}_{\text{Cu}}$ do not cause obvious CBM downshift or VBM upshift, and thus do not trap electrons or holes.

◆ $2\text{Cu}_{\text{Zn}}+\text{Sn}_{\text{Zn}}$ causes large CBM downshift, and thus can trap electrons.



Carrier Transition Rate to Defect State



nonradiative decay probability

$$W_{fi} = \frac{2\pi}{\hbar} \sum_m \sum_n p(i,m) \left| \sum_k \langle \psi_f | \frac{\partial H}{\partial Q_k} | \psi_i \rangle \langle \chi_n | \mathbf{Q}_k | \chi_m \rangle \right|^2 \times \delta(\Delta E + E_m - E_n), \quad (1)$$

probability that the system is in the initial phonon state m

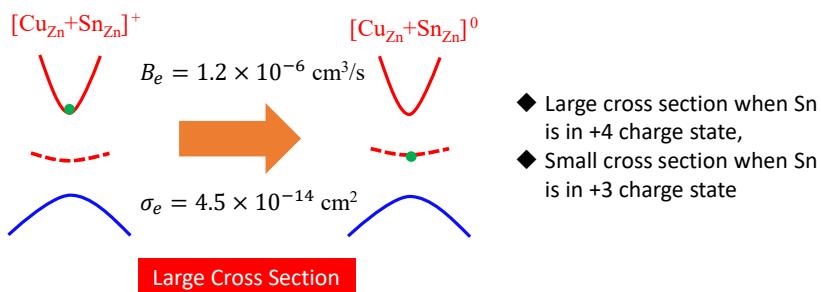
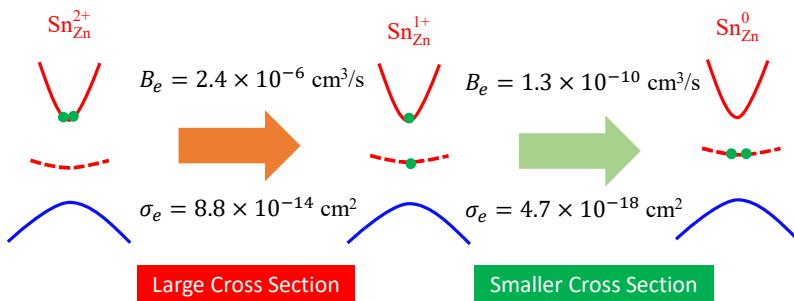
electron-phonon coupling matrix elements

lattice transition matrix elements between the initial and final phonon states

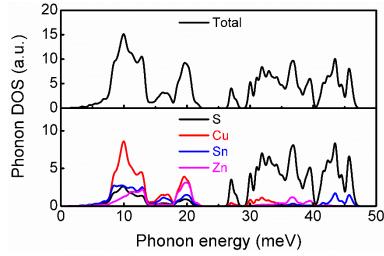
L. Shi, K. Xu, L.-W. Wang, Phys. Rev. B 91, 205315 (2015)

L. Shi and L.-W. Wang, Phys. Rev. Lett. 109, 245501 (2012)

Calculated Carrier Capture Cross Sections

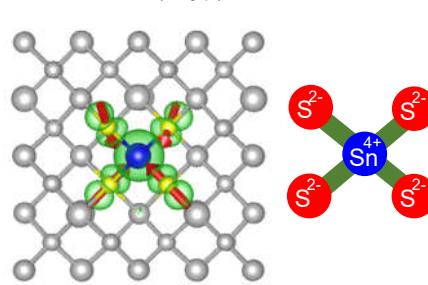
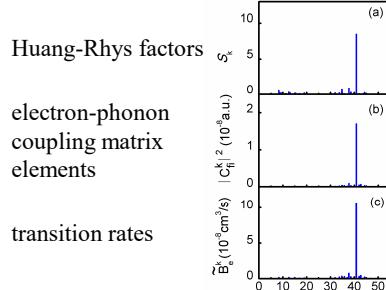


Phonons that induce Non-radiate Recombination

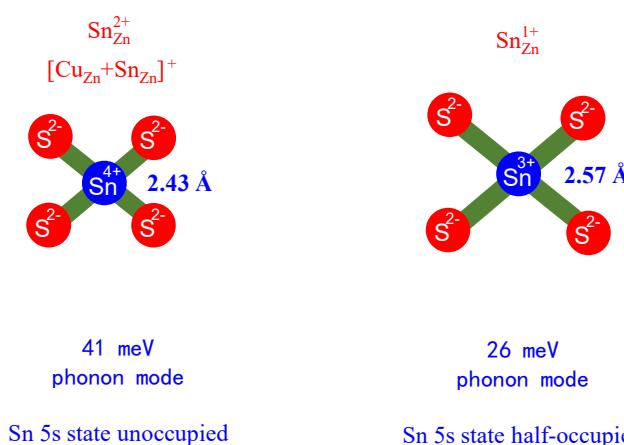


- ◆ 41 meV phonon mode is localized around the defect and is the stretching mode of Sn-S bonds
- ◆ Overlapping of the defect electronic state and phonon mode, thus strong electron-phonon coupling

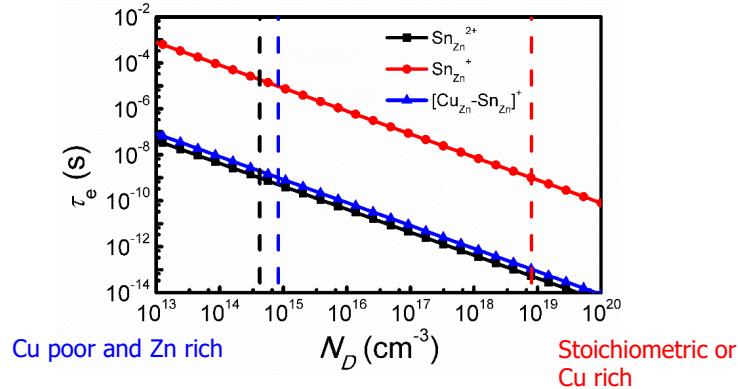
$$\langle \psi_f | \frac{\partial H}{\partial Q_k} | \psi_i \rangle$$



Phonon Mode Softening



Limit to the Lifetime of Minority Carriers



◆当这两类复合中心缺陷浓度高于 10^{15} cm^{-3} 时，
少子寿命将短于 1ns

Li, et al. Phys. Rev. B 96, 104103 (2017); Chem. Mater. 31, 826 (2019)

带尾态和深能级复合中心的来源缺陷

J. Phys. Chem. Lett. 2019, 10, 7929–7936

Origin of Band-Tail and Deep-Donor States in $\text{Cu}_2\text{ZnSnS}_4$ Solar Cells and Their Suppression through Sn-Poor Composition

Suyu Ma,^{†,#} Hongkai Li,^{†,#} Jin Hong,^{†,#} Han Wang,[†] Xiaoshuang Lu,[†] Ye Chen,[†] Lin Sun,^{*,†,◎} Fangyu Yue,^{*,†} Jens W. Tomm,[‡] Junhao Chu,^{†,§} and Shiyou Chen^{*,†,○}

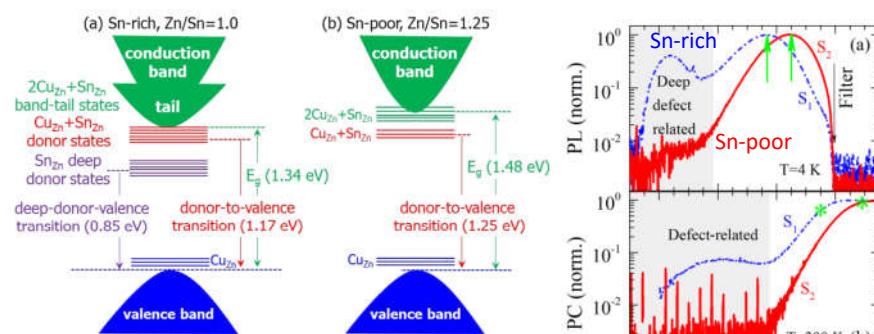


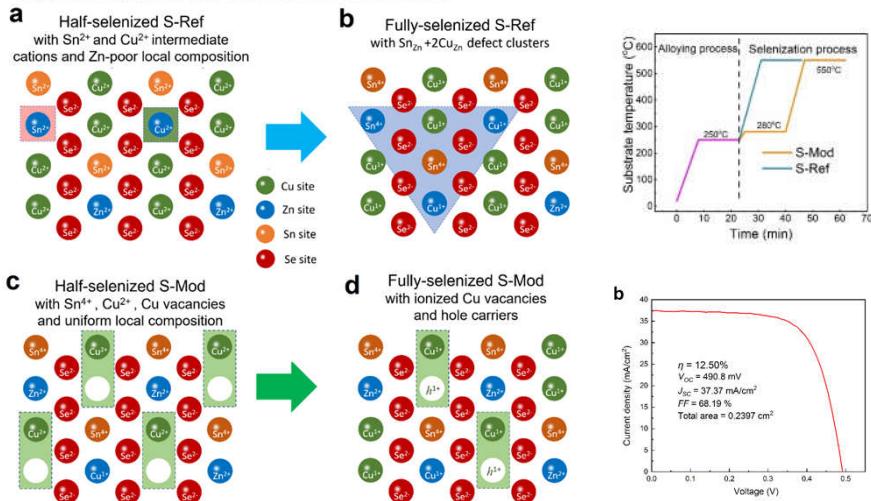
Figure 4. Schematic of the band-tail and donor states induced by Sn_{Zn} and the related defect clusters $2\text{Cu}_{\text{Zn}} + \text{Sn}_{\text{Zn}}$ and $\text{Cu}_{\text{Zn}} + \text{Sn}_{\text{Zn}}$ in the bandgaps of (a) Sn-rich CZTS with $\text{Zn/Sn} = 1.0$ and (b) Sn-poor CZTS with $\text{Zn/Sn} = 1.25$.

缺陷调控提升太阳能电池效率

Adv. Mater. In press

WILEY-VCH

Defect control for 12.5% efficiency Cu₂ZnSnSe₄ kesterite thin-film solar cells by engineering of local chemical environment ↵



低对称性光伏半导体

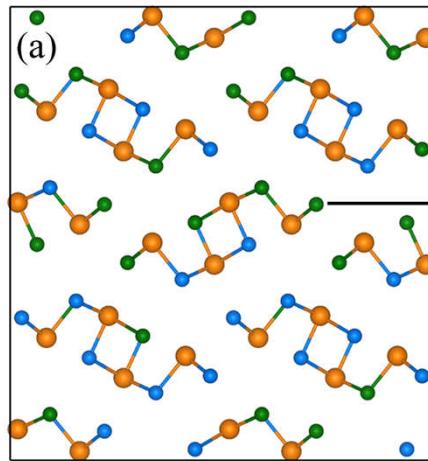
Sb₂(S,Se)₃ alloys

Sb ₂ Se ₃	1.2 eV
Sb ₂ S ₃	1.6-1.7 eV
Bi ₂ S ₃	1.3-1.45 eV

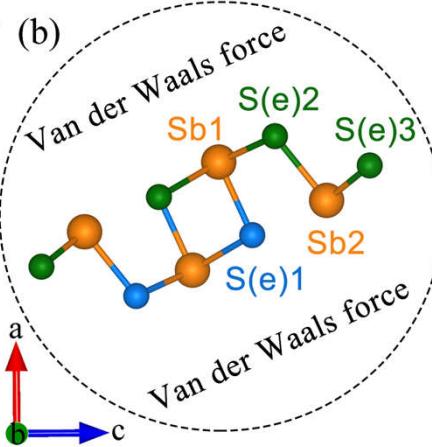
M. Huang, et al. ACS Appl. Mater. Interfaces 11, 15564 (2019).
 Z. Cai, et al. Solar RRL 4, 1900503 (2020).
 D. Han, et al. Journal of Materials Chemistry A 5, 6200 (2017)

quasi-1D Semiconductors Sb_2Se_3 , Sb_2S_3 , Bi_2S_3

Sb_2Se_3 , Sb_2S_3 , Bi_2S_3

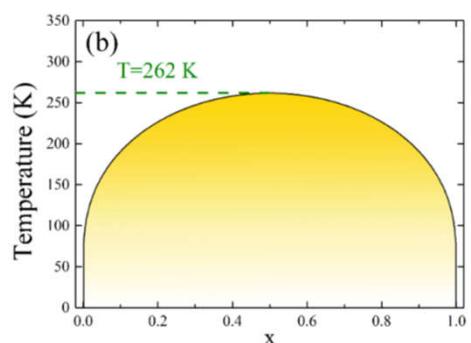
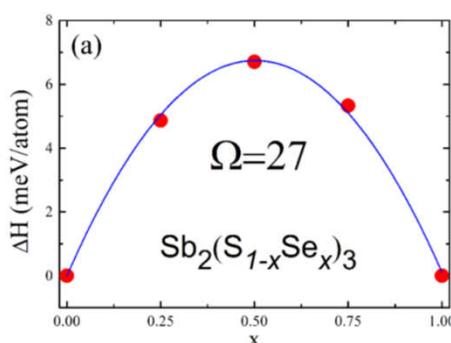


quasi-1D structure



Zhou et al. Nature Photonics 9, 409 (2015)

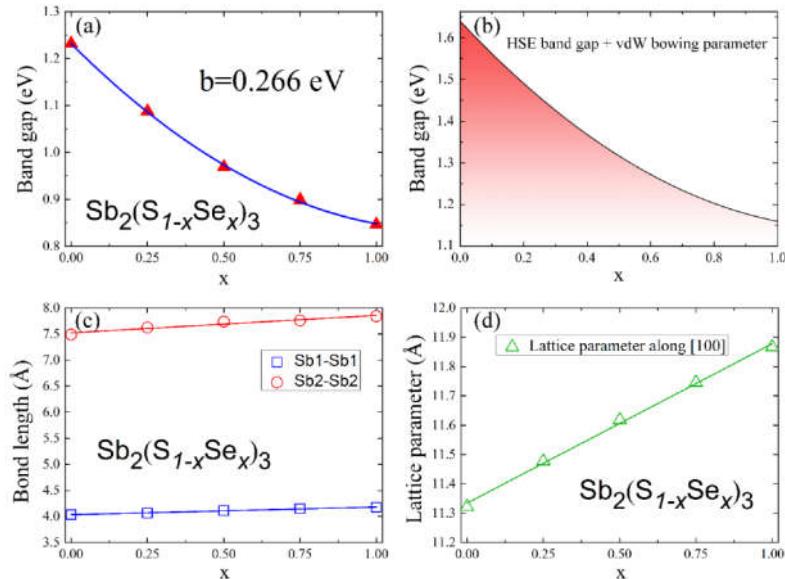
Highly miscible $\text{Sb}_2(\text{S},\text{Se})_3$ alloys



- The $\text{Sb}_2(\text{S},\text{Se})_3$ alloy is highly miscible under room temperature.
- The mixing enthalpy is 27 meV/atom (or 45 meV/mixed-atom), lower than that of $\text{Cu}_2\text{ZnSn}(\text{S},\text{Se})_4$ (52 meV/mixed-atom) and $\text{Cu}(\text{In},\text{Ga})\text{Se}_2$ (176 meV/mixed-atom).

M. Huang et al., J. Chem. Phys. 153, 014703 (2020)

Linear dependence of bandgaps on composition



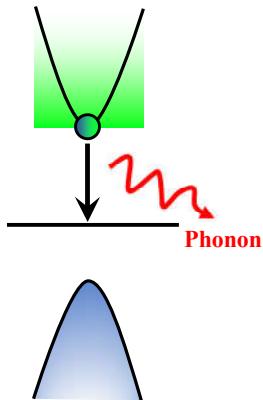
Sb₂Se₃相关无机半导体

$\text{Sb}_2(\text{S},\text{Se})_3$ alloys	$\left\{ \begin{array}{ll} \text{Sb}_2\text{Se}_3 & 1.2 \text{ eV} \\ \text{Sb}_2\text{S}_3 & 1.6-1.7 \text{ eV} \\ \text{Bi}_2\text{S}_3 & 1.3-1.45 \text{ eV} \end{array} \right.$
--	--

Very flexible properties,
but many defects!

M. Huang, *et al.* ACS Appl. Mater. Interfaces 11, 15564 (2019)
Z. Cai, *et al.* Solar RRL 4, 1900503 (2020); J. Appl. Phys. 127, 183101 (2020)
D. Han, *et al.* Journal of Materials Chemistry A 5, 6200 (2017)

How many point defects in Sb_2Se_3

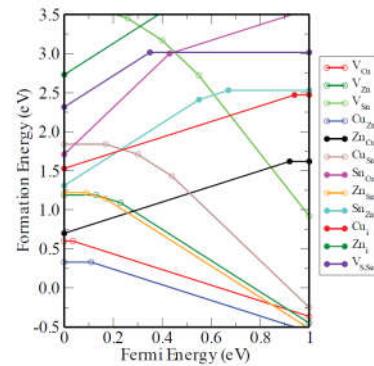


Deep defect levels acting as non-radiative recombination center limit the photovoltaic performance.

Sb_2Se_3

V_{Sb}
 V_{Se}
 Sb_{Se}
 Se_{Sb}
 Sb_i
 Se_i

$\text{Cu}_2\text{ZnSnS}_4$

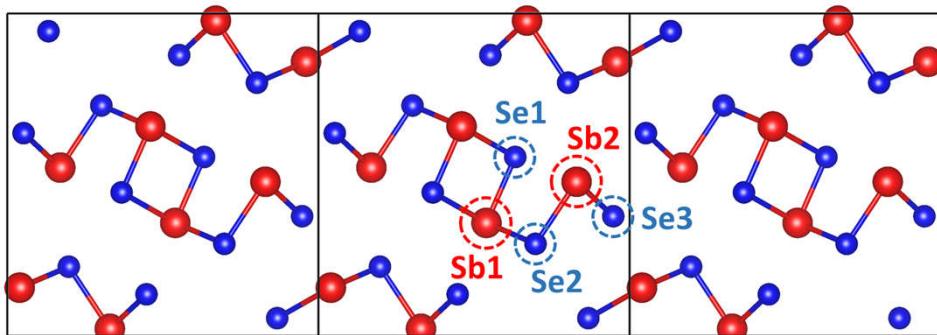


Only 6 defects

Dozens of defects

X. Liu, et al. Prog. Photovolt. 25, 861 (2017)

Defects at non-equivalent Atomic Sites

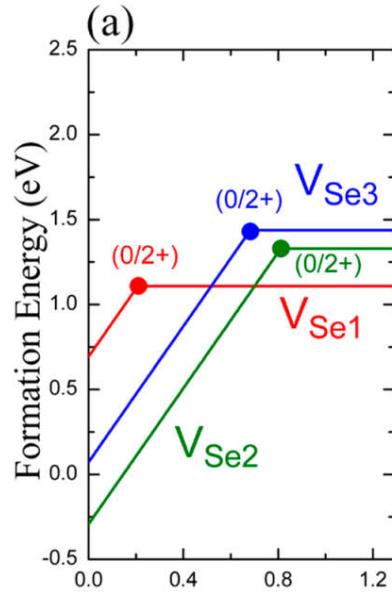
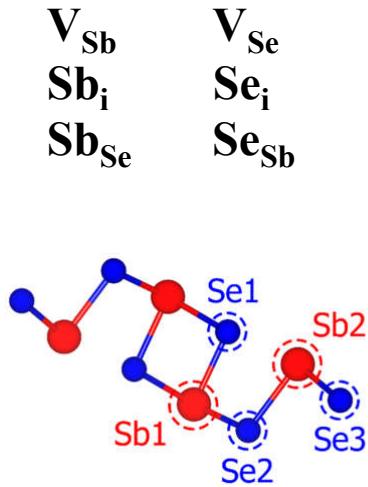


3 Se sites and 2 Sb sites!

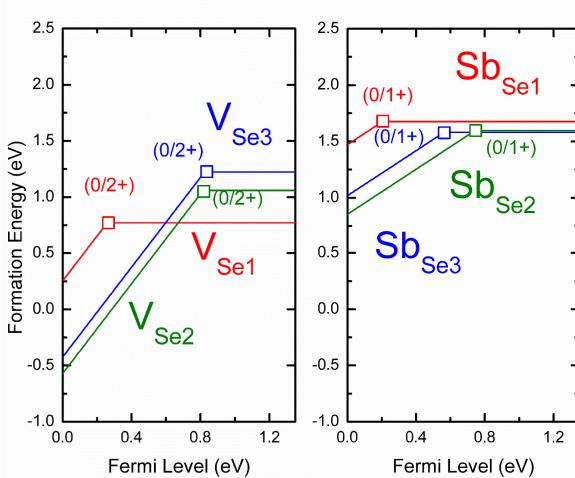
Se sites: $\text{V}_{\text{Se}1}$, $\text{V}_{\text{Se}2}$, $\text{V}_{\text{Se}3}$, **Sb sites:** $\text{V}_{\text{Sb}1}$, $\text{V}_{\text{Sb}2}$, $\text{Sb}_{\text{Se}1}$, $\text{Sb}_{\text{Se}2}$, $\text{Sb}_{\text{Se}3}$
 $\text{Se}_{\text{Sb}1}$, $\text{Se}_{\text{Sb}2}$

Huang et al. ACS Appl. Mater. Interfaces 11, 15564 (2019)

Three different Se vacancies in Sb_2Se_3

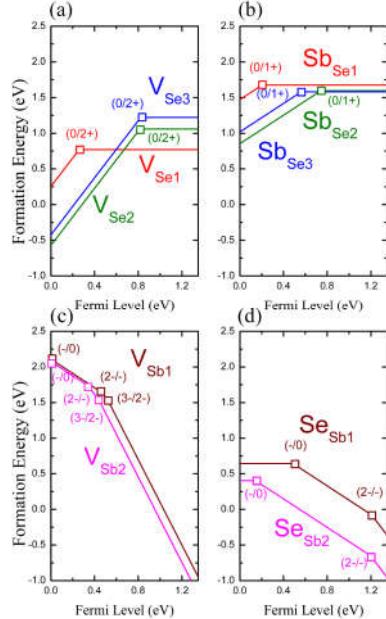


V_{Se} and Sb_{Se}



- ◆ V_{Se} is a deep donor for all Se sites: $V_{\text{Se}1}$ is much deeper than $V_{\text{Se}2}$ and $V_{\text{Se}3}$.
- ◆ Sb_{Se} has almost the same formation energy for all Se sites at neutral states, however, their transition levels (0/1+) are different.

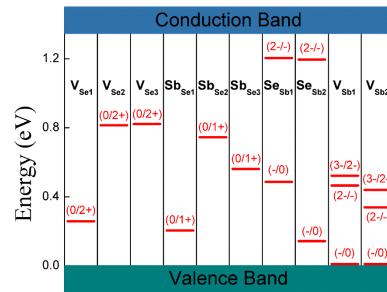
Defects on Different Atomic Sites



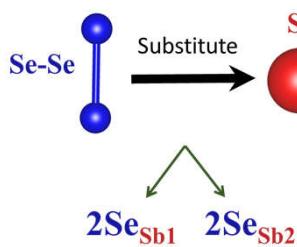
◆ Defects at non-equivalent sites have quite different properties

◆ Se_{Sb} and Sb_{Se} antisites can have high concentration

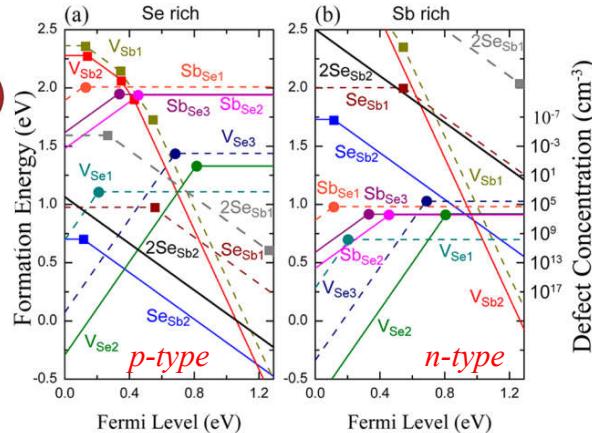
◆ Se_{Sb} is an acceptor



More abnormal defects with high concentration

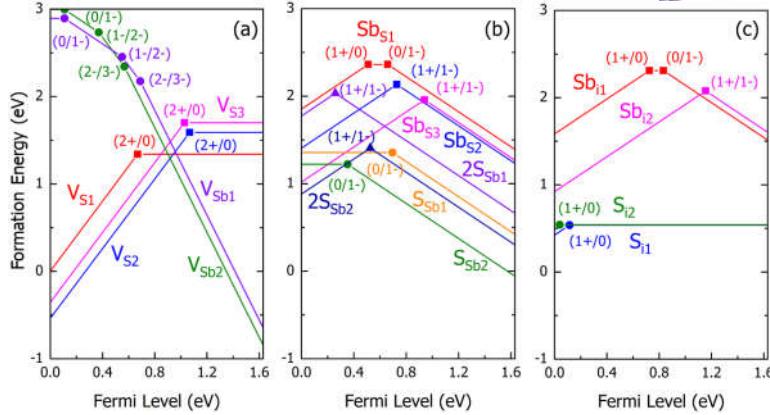


- $2Se_{Sb2}$ can have high concentration under Se-rich condition.



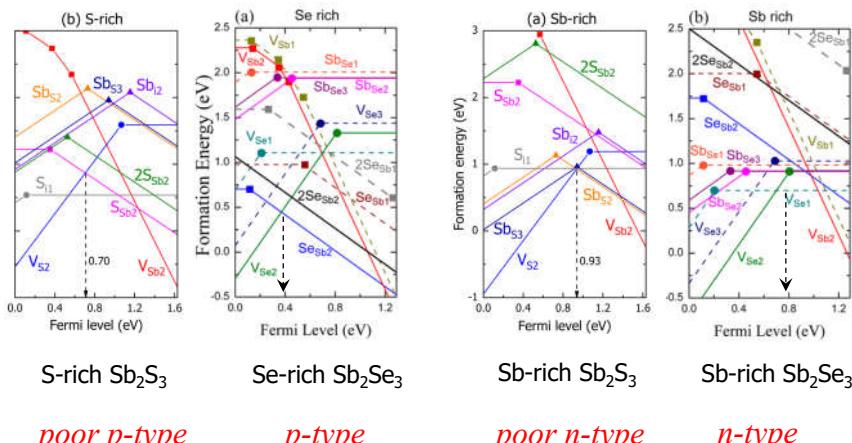
- ◆ There are high concentration of recombination center defects under both the Se-rich and Sb-rich condition, so the passivation of these unavoidable defects may be critical to the further optimization of Sb_2Se_3 solar cells.
- ◆ Defects are as complicated as those in multinary compounds.

Non-equivalent defects in Sb_2S_3



- ◆ Cation-replace-anion antisite defects can act as acceptor ($\text{Sb}_{\text{S}1}$, $\text{Sb}_{\text{S}2}$, and $\text{Sb}_{\text{S}3}$).
- ◆ Formation energies of antisite defects and S_i can be quite low.
- ◆ Defect complexes are easy to form in Sb_2S_3 ($2\text{S}_{\text{S}1}$, $2\text{S}_{\text{S}2}$).

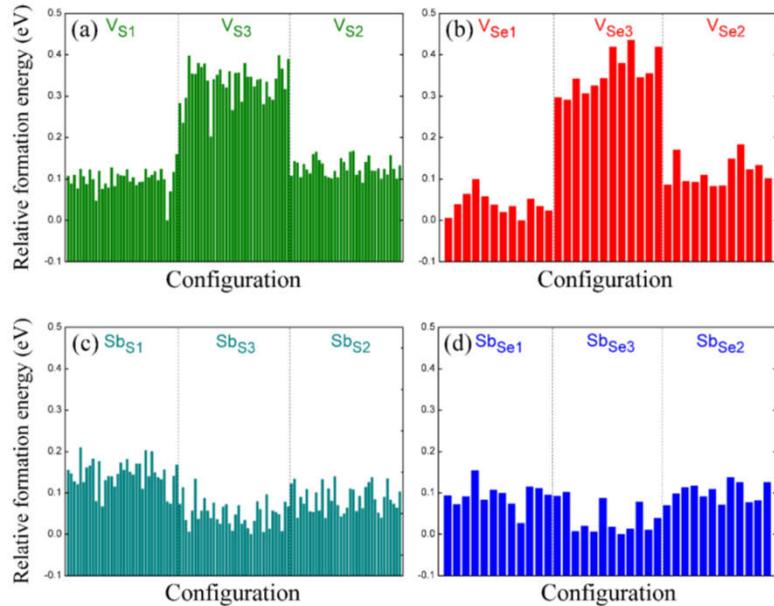
Origins of High Resistivity of Intrinsic Sb_2S_3



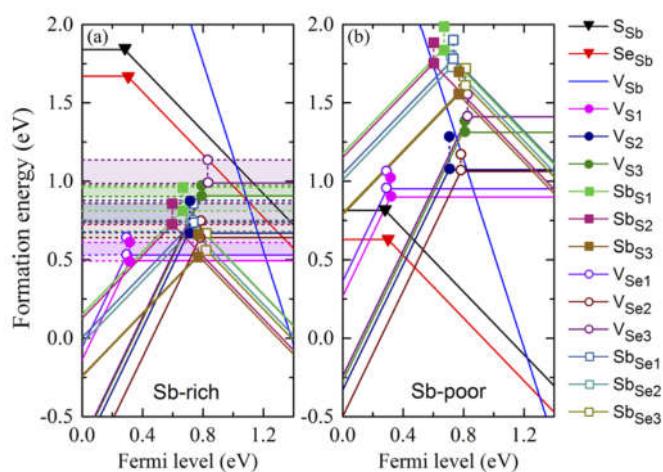
- ◆ High concentration (low formation energy) of deep-level defects.
- ◆ The electrical conductivity of Sb_2S_3 is limited by intrinsic point defects.

Z. Cai, et al. Solar RRL 4, 1900503 (2020); J. Appl. Phys. 127, 183101 (2020)

Defects in the $\text{Sb}_2(\text{S},\text{Se})_3$ alloys



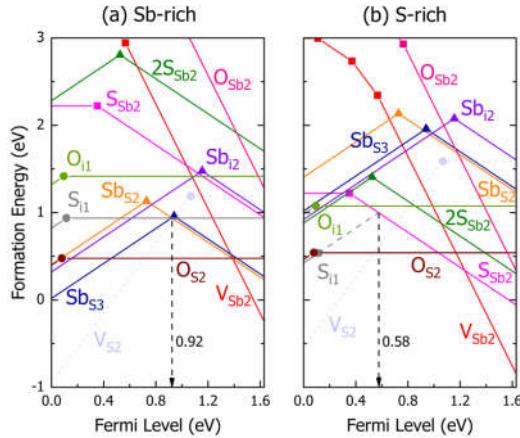
Defect formation energies



M. Huang *et al.*, J. Chem. Phys. 153, 014703 (2020)
R. Tang *et al.*, Nature Energy 5 (8), 587-595 (2020)

Strategies for increasing carrier concentration

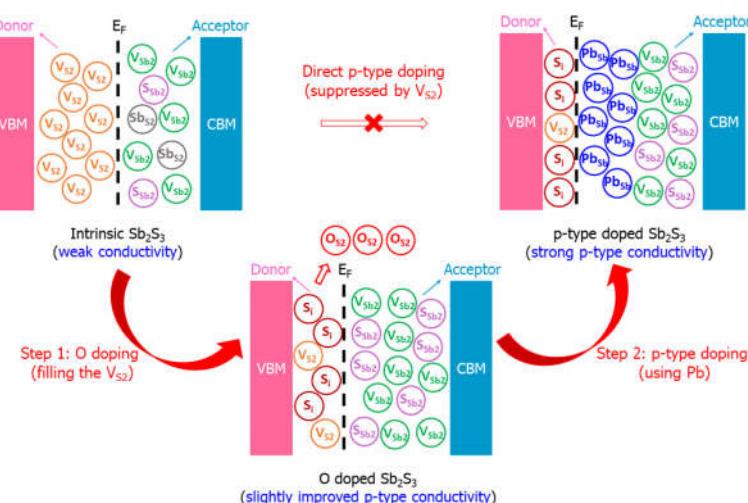
Unintentional dopants: O impurity



- ◆ Low formation energy of O_{S2} .
- ◆ The dominant donor V_{S2} is filled, making the p-type doping easy to be realized.

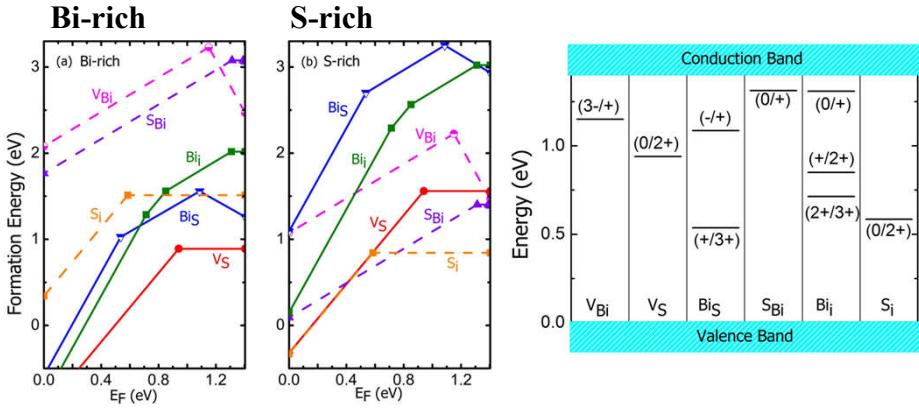
Strategies for achieving high hole concentration

Method II: Using the unexpected effect of O doping



Z. Cai et al., Solar RRL 4, 1900503 (2020).

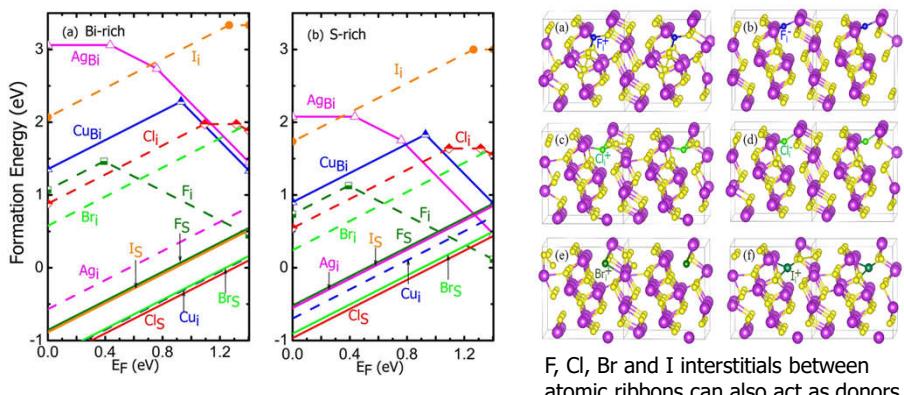
Intrinsic Defects in Bi_2S_3



Abnormal characters:

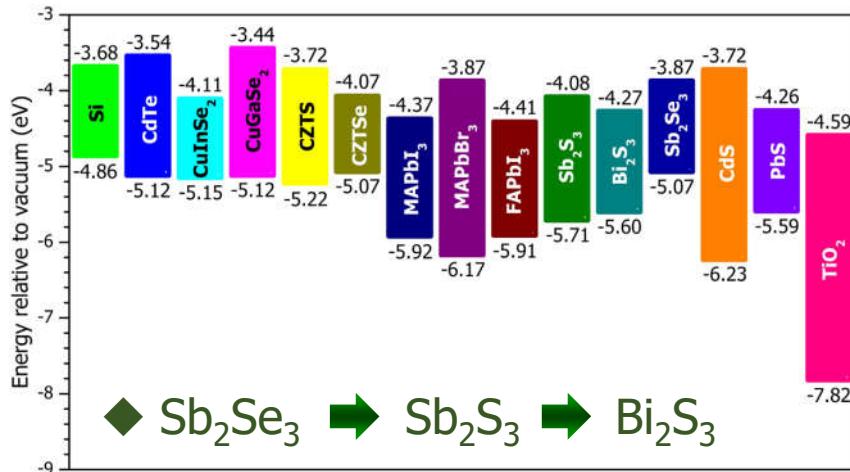
- ◆ S_i is a donor, and Sb_S and S_{Sb} have low formation energies, similar to those in Sb_2S_3
- ◆ Almost all defects are donors, so Bi_2S_3 is always n-type intrinsically.
- ◆ High concentration of deep-level defects, so the minority carrier lifetime is limited and thus Bi_2S_3 is not a good light-absorber semiconductor

Cu, Ag, F, Cl, Br and I doping in Bi_2S_3



- ◆ All these dopants prefer acting as donors
 - ① Cu and Ag prefer interstitial sites
 - ② F, Cl, Br and I prefer the anion sites, replacing S
- ◆ Very good n-type conductivity can be achieved by doping with Cu, Cl and Br
- ◆ Bi_2S_3 may be an ideal n-type electron acceptor or counter electrode material

Band Edge Position and Doping Limit



Conclusions

- ◆ Cu₂ZnSn(S,Se)₄ Multinary
Complicated Defects
- ◆ Sb₂Se₃, Sb₂S₃, Bi₂S₃ Low-Symmetry
Chemically Binary, Structurally Multinary
Complicated Defects

提纲

1. 计算辐照下可能产生的各种缺陷的平衡态性质
形成能、能级和载流子俘获截面

2. 模拟辐照下化学键的断裂和缺陷形成过程

电子束辐照下半导体缺陷的产生

P-Type Conduction in Mg-Doped GaN Treated with Low-Energy Electron Beam Irradiation (LEEBI)

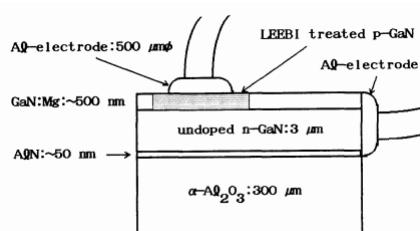
Hiroshi AMANO, Masahiro KITO, Kazumasa HIRAMATSU
and Isamu AKASAKI

Department of Electronics, Nagoya University, Furo-cho, Chikusa-ku, Nagoya 464-01
(Received October 6, 1989; accepted for publication November 8, 1989)



中村修二

JAPANESE JOURNAL OF APPLIED PHYSICS
VOL. 28, NO. 12, DECEMBER, 1989, pp. L 2112-L 2114



低能电子束辐照导致半导体缺陷的产生和演化，可提高GaN的p型导电性

The Hall effect measurement of this Mg-doped GaN treated with LEEBI at room temperature showed that the hole concentration is $\sim 2 \cdot 10^{16} \text{ cm}^{-3}$, the hole mobility is $\sim 8 \text{ cm}^2/\text{V}\cdot\text{s}$ and the resistivity is $\sim 35 \Omega\cdot\text{cm}$. The p-n junction LED using Mg-doped GaN treated with LEEBI as the p-type material showed strong near-band-edge emission due to the hole injection from the p-layer to the n-layer at room temperature.

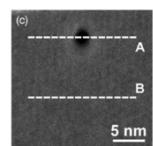
S. Nakamura, N. Iwasa, M. Senoh, and T. Mukai, Jpn. J. Appl. Phys., Part 1 **31**, 1258 (1992).

电子束辐照对材料的影响

Radiation Damage
(Electron Beam Induced)

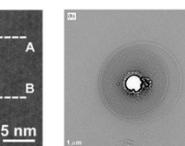
Elastic

Knock-On
displacement



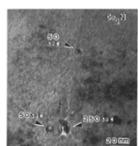
O. Ugurlu et al.,
Phys. Rev. B
83, 113408 (2013).

Electrostatic
charging



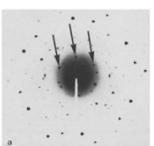
D. Radostin et al.,
Ultramicroscopy
88, 243 (2001).

Sputtering



L. E. Thomas,
Ultramicroscopy
18, 173 (1985).

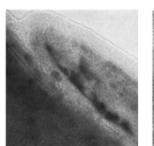
Radiolysis-
Ionization



R. Henderson et al.,
Ultramicroscopy
16, 139 (1985).

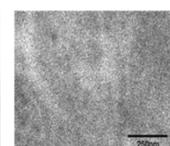
Inelastic

Heating



M. Liu et al.,
Scanning
16, 1 (1994).

Hydrocarbon
contamination



S. Charles et al.,
Microscopy Today
20, 44 (2012).

制约TEM技术在有机-无机杂化半导体 ($\text{CH}_3\text{NH}_3\text{PbI}_3$) 上的应用

电子束辐照引起的两种材料损伤机制

Knock-On Displacement

*Electron-nuclei driven process
*Elastic

Inorganic Conducting
Materials



Inorganic Conducting
Materials

Radiolysis-Ionization

*Electron-electron driven process
*Inelastic



Inorganic Materials

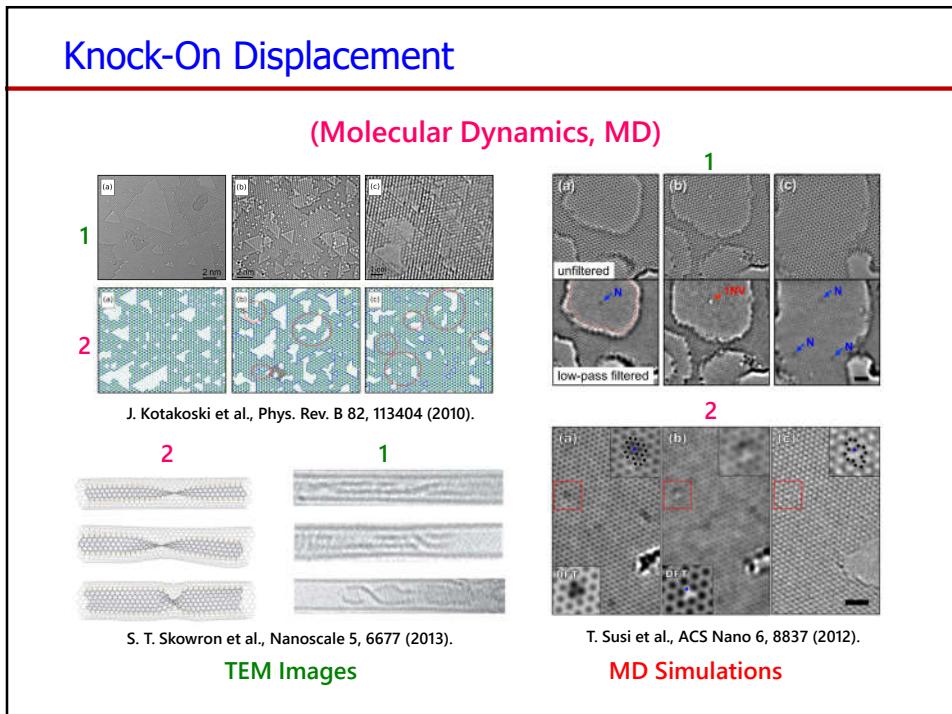
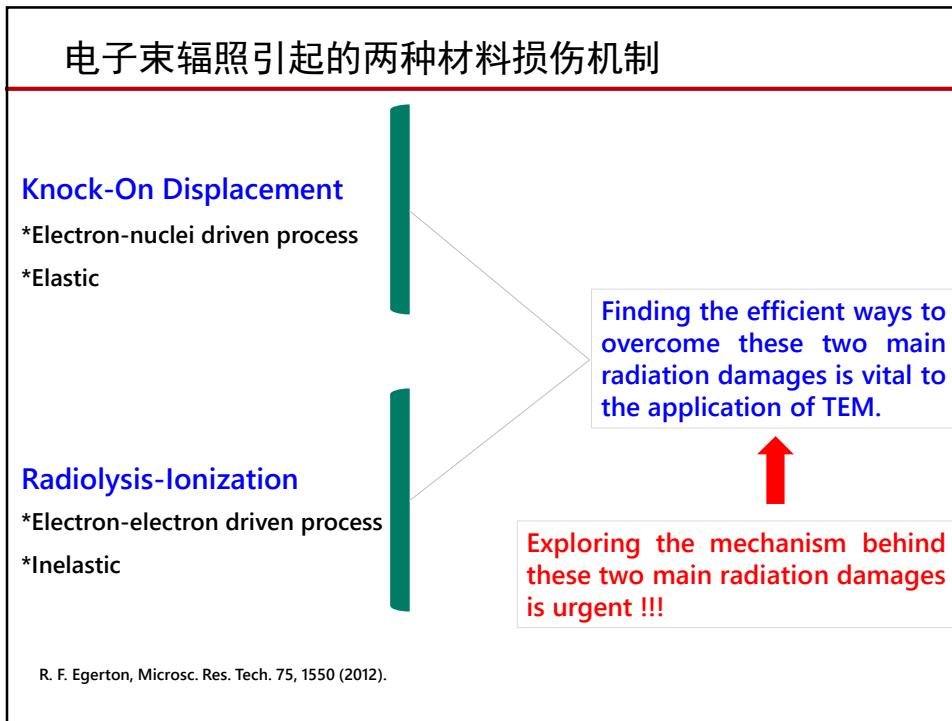


Organic Materials



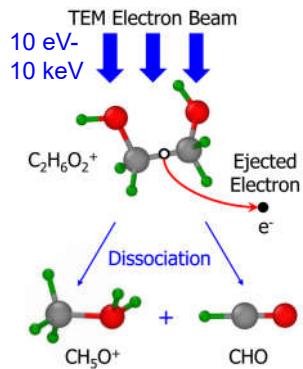
Molecules

R. F. Egerton, Microsc. Res. Tech. 75, 1550 (2012).



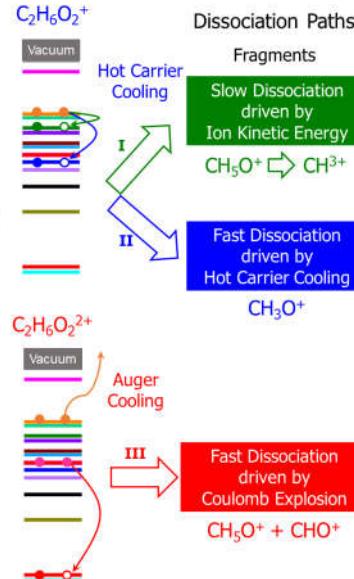
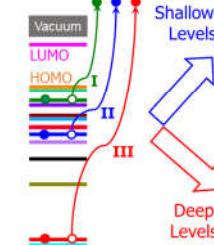
Radiolysis-Ionization Induced Molecule Dissociation

Radiolysis Ionization



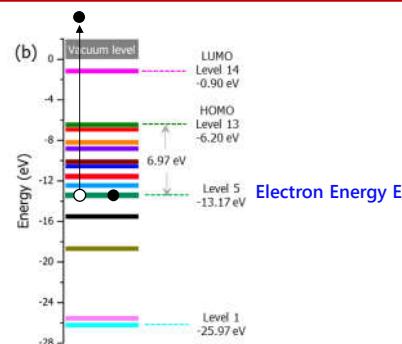
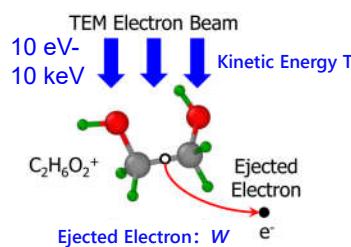
M. Y. Mykyta et al., Ukr. J. Phys. 56, 116 (2011).
D. Bouchiba et al., J. Phys. B 40, 1259 (2007).
R. Völpel et al., Phys. Rev. Lett. 71, 3439 (1993).
F. L. Arnot, Nature 129, 617 (1932).
L. Sanche, Mass Spectrom. Rev. 21, 349 (2002).

$\text{C}_2\text{H}_6\text{O}_2$
Radiolysis
Ionization



Ionization Cross-Section

Binary encounter-dipole (BED) model



Total Cross Section σ

$$\sigma(t) = \frac{S}{t+u+1} \left[D(t) \ln t + \left(2 - \frac{N_i}{N}\right) \left(\frac{t-1}{t} - \frac{\ln t}{t+1}\right) \right]$$

$$t = T/E \quad w = W/E \quad u = U/E$$

Y.-K. Kim et al., Phys. Rev. A 50, 3954 (1994).
M. Inokuti, Rev. Mod. Phys. 43, 297 (1971).

$$S = 4\pi a_0^2 N(R/E)^2$$

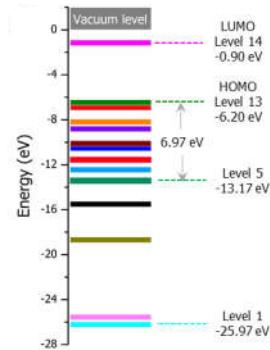
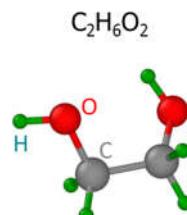
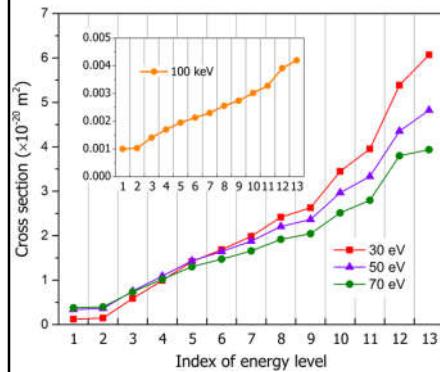
$$N_i \equiv \int_0^\infty \frac{df(w)}{dw} dw;$$

$$D(t) = N^{-1} \int_0^{(t-1)/2} \frac{1}{w+1} \frac{df(w)}{dw} dw$$

$$\frac{df(w)}{dw} = (E(w+1)/R)(qa_0)^{-2} \sum_B |\epsilon(q)|^2$$

$$\epsilon(q) = \langle \phi_1 | \sum_{j=1}^Z \exp(i\vec{q} \cdot \vec{r}_j) | \phi_0 \rangle$$

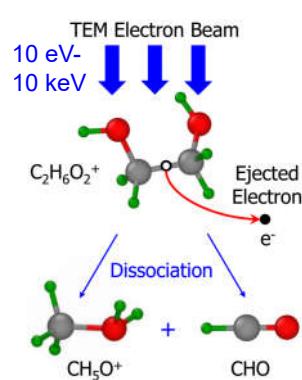
Calculated Ionization Cross-Section



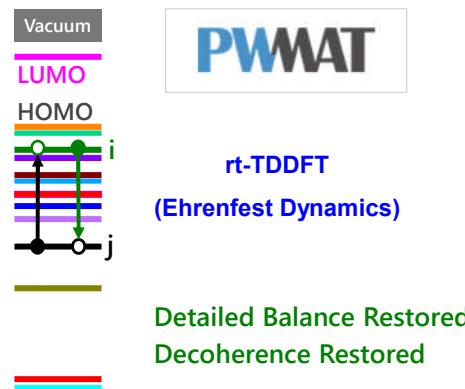
- ❖ Decreasing monotonously from Level 13 to Level 1.
- ❖ Decreasing as the energy of the incident electron beam increases, except for the very deep levels (Level 1-4).
- ❖ Quite small for the high energy electron beam due to the short passing time.

Simulating Radiolysis-Ionization Induced Molecule Dissociation

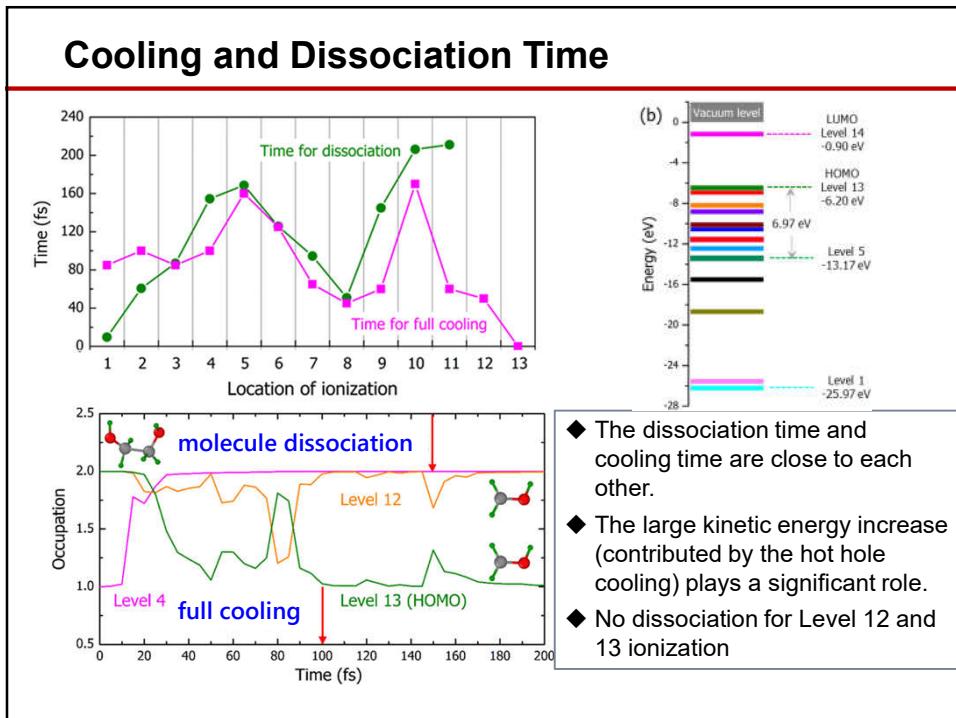
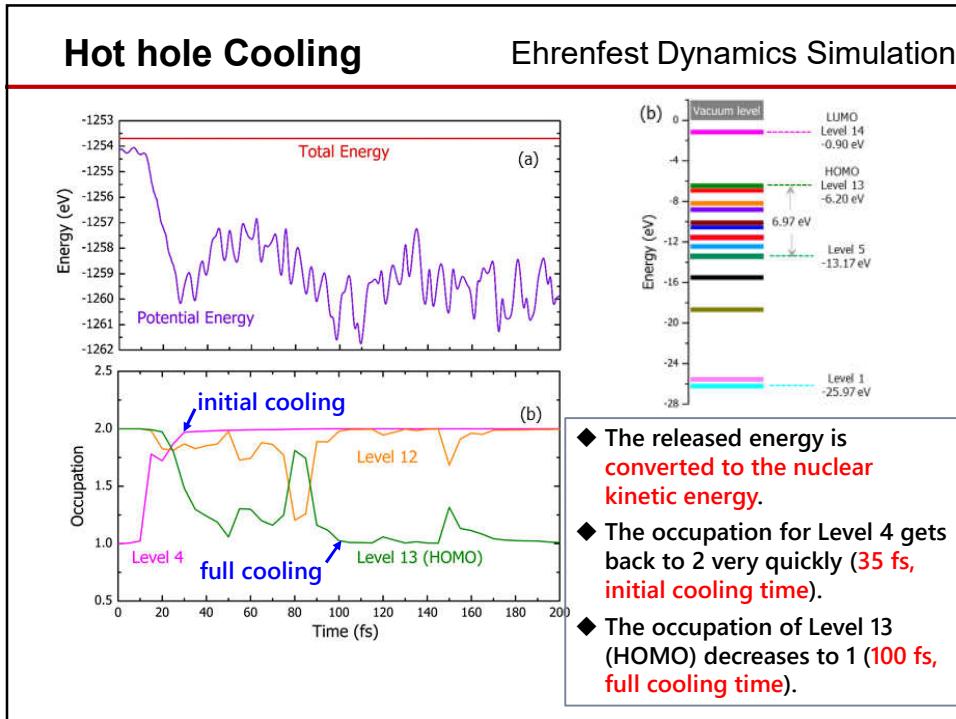
Radiolysis Ionization



Hot carrier cooling

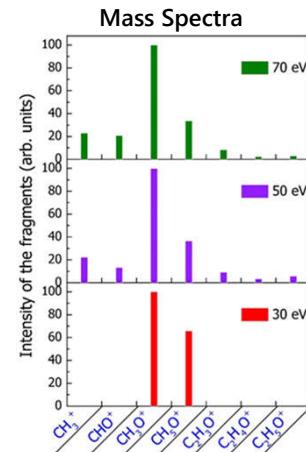


J. Kang et al., Phys. Rev. B 99, 224303 (2019).



Dissociation Fragments

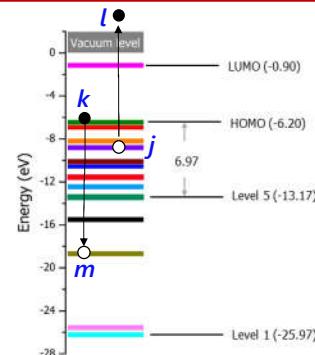
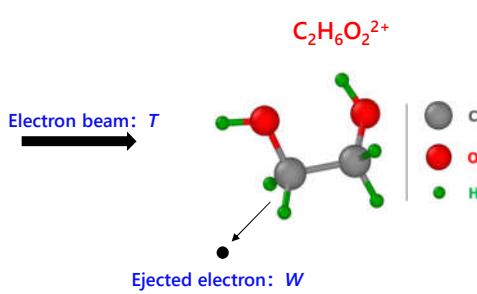
Ionization Level	Dissociation to different fragments
1	$\text{C}_2\text{H}_6\text{O}_2^+ \rightarrow \text{C}_2\text{H}_5\text{O}^+ (\text{CH}_3\text{CHOH}^+) + \text{OH}$
2	$\text{C}_2\text{H}_6\text{O}_2^+ \rightarrow \text{C}_2\text{H}_5\text{O}^+ (\text{CH}_2\text{CH}_2\text{OH}^+) + \text{OH}$
3-11	$\text{C}_2\text{H}_6\text{O}_2^+ \rightarrow \text{CH}_3\text{O}^+ + \text{CH}_3\text{O}$
12-13	No dissociation observed



M. Y. Mykyta et al., Ukr. J. Phys. 56, 116 (2011).

- ◆ Highest peak of CH_3O^+ : explained
- ◆ $\text{C}_2\text{H}_5\text{O}^+$: strange, less at high energy beam energy.

Auger Decay



Auger Decay Rate

$$\tau^{-1} = \frac{\Gamma}{\hbar} \sum_l \frac{|J(j, k, l, m)|^2}{(\Delta E)^2 + (\Gamma/2)^2}$$

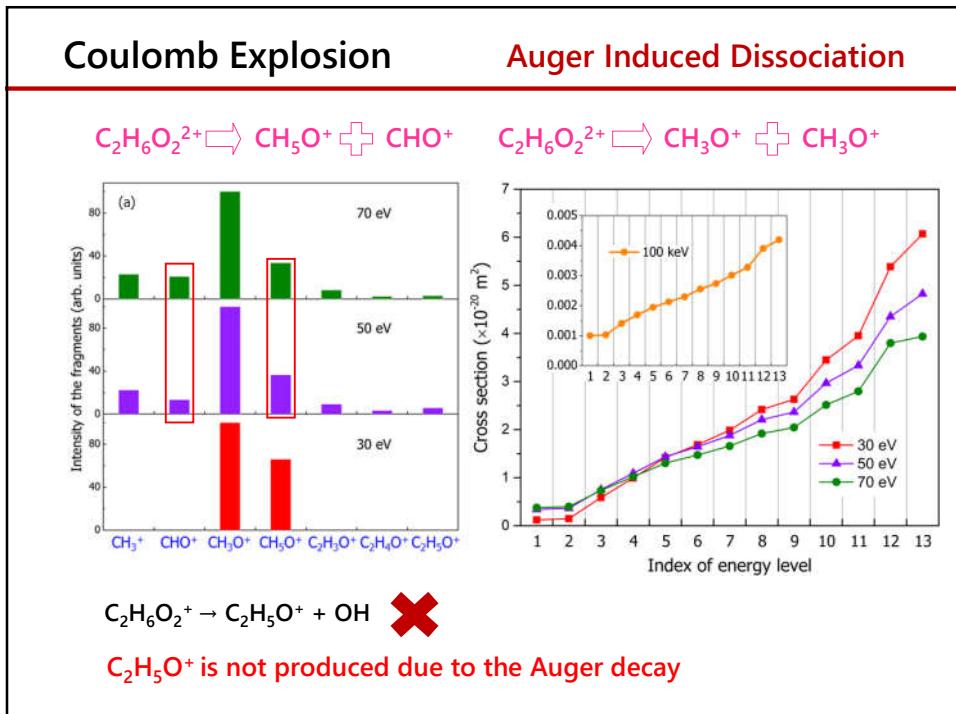
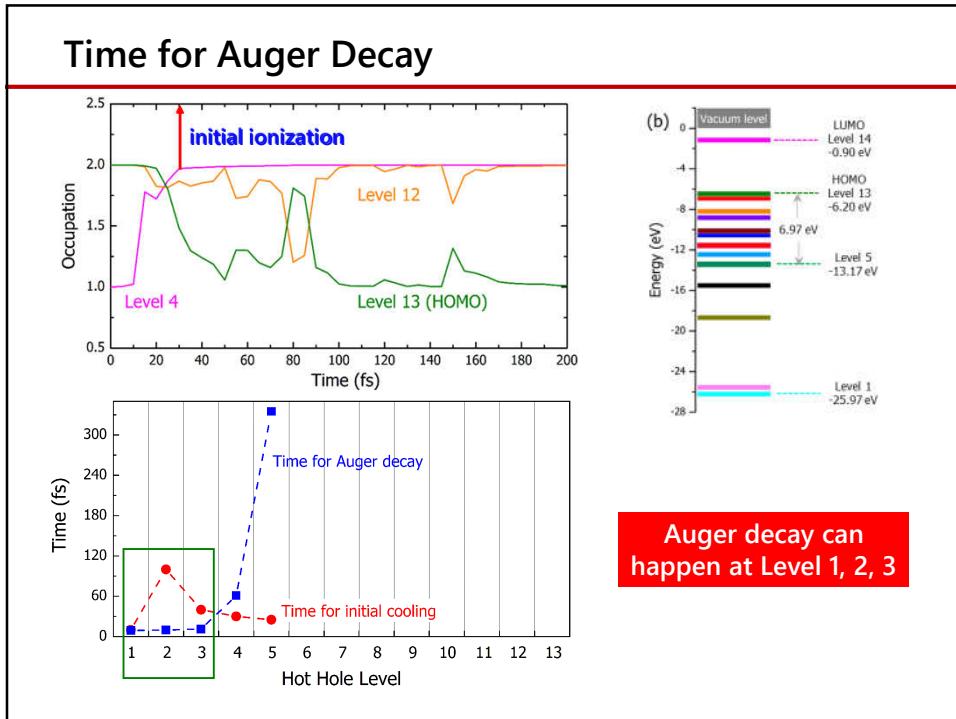
L.-W. Wang et al., Phys. Rev. Lett. 91, 056404 (2003).

$$J(j, k, l, m)$$

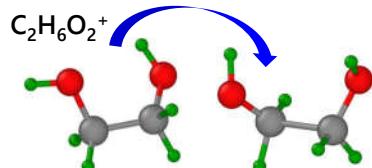
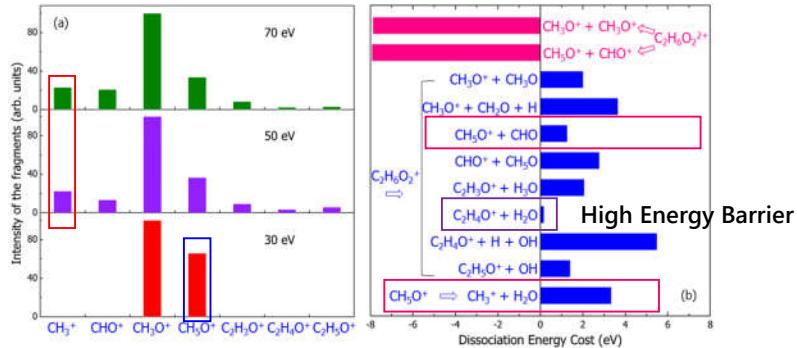
$$= \iint \phi_j^*(\mathbf{r}, \beta) \phi_k^*(\mathbf{r}', \alpha) \frac{e^2}{|\mathbf{r} - \mathbf{r}'|} \phi_l(\mathbf{r}, \beta) \phi_m(\mathbf{r}', \alpha) d^3r d^3r'$$

$$\Delta E = E(k) - E(m) + E(j) - E(l)$$

phonon broadening factor $\Gamma = 30$ meV

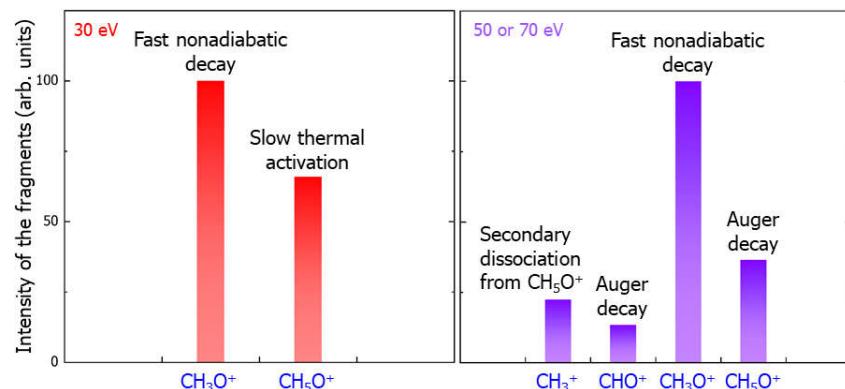


Slow Thermodynamic Dissociation



- ◆ Structure reorganization energy
- ◆ Kinetic energy from hot carrier cooling

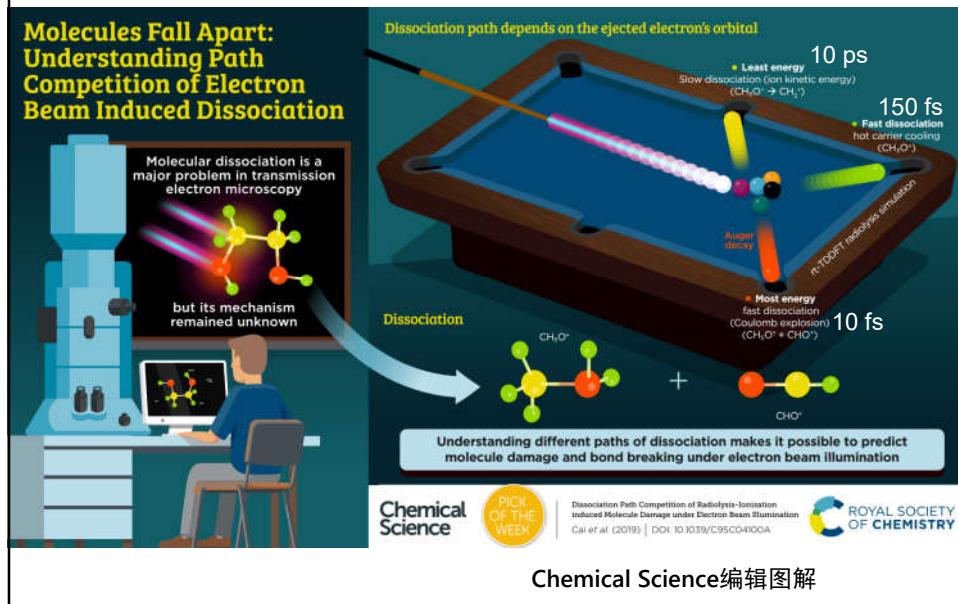
Mass Spectra of Dissociation Fragments



The underlying mechanisms of the main peaks to different dissociation channels under the illumination of electron beams with different incident energies is assigned.

Cai *et al.* Chem. Sci. (2019) DOI: 10.1039/C9SC04100A

TEM中离化分子的多种分裂机制相互竞争



Method Framework for Simulating Radiolysis-Ionization

Probability of Initial Ionization
Binary Encounter-Dipole (BED) Model

Y.-K. Kim et al., Phys. Rev. A 50, 3954 (1994).

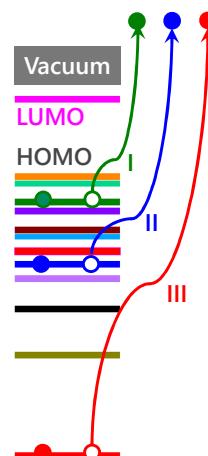
Auger Caused Dissociation
Analytical Formalism with Fermi-Golden Rule

L.-W. Wang et al., Phys. Rev. Lett. 91, 056404 (2003).

Hot Carrier Cooling Induced Dissociation
Real-time time-dependent density functional theory (rt-TDDFT)

Z. Wang et al., Phys. Rev. Lett. 114, 063004 (2015).

Slow Thermodynamic Dissociation
Thermodynamic energy analysis



Cai et al. Chem. Sci. (2019) DOI: 10.1039/C9SC04100A

提纲

1. 计算辐照下可能产生的各种缺陷的平衡态性质
形成能、能级和载流子俘获截面
2. 模拟辐照下化学键的断裂和缺陷形成过程

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